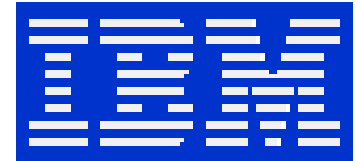


Spin Transport in the Magnetic Tunneling Transistors

Stuart Parkin

IBM Almaden Research Center, San Jose, California

- Introduction to spin-based electronics
- Introduction to magnetic tunnel transistor (MTT)
- Use MTTs to study spin-dependent hot electron transport
 - spin-dependent electron attenuation lengths in thin films
 - bias voltage dependence of magnetocurrent
 - MTT with a spin-valve base
- Spin injection from MTTs into GaAs
- Spin-based devices



Supported in part by the United States
Defense Advanced Research Project Agency (DARPA)



Spin-Based Electronics

- **Conventional electronics: utilizing the charge of carriers**
- **Spin-based electronics: utilizing the spin of carriers**
- **Key components for spintronic devices:**
 - **Generate spins:**
 - ferromagnetic metals, diluted magnetic semiconductors etc.
 - **Transport spins:**
 - from spin-polarized source into metals or semiconductors
 - **Manipulate spins:**
 - electrical field, magnetic field etc.
 - **Detect spins:**
 - electrical detection, optical detection

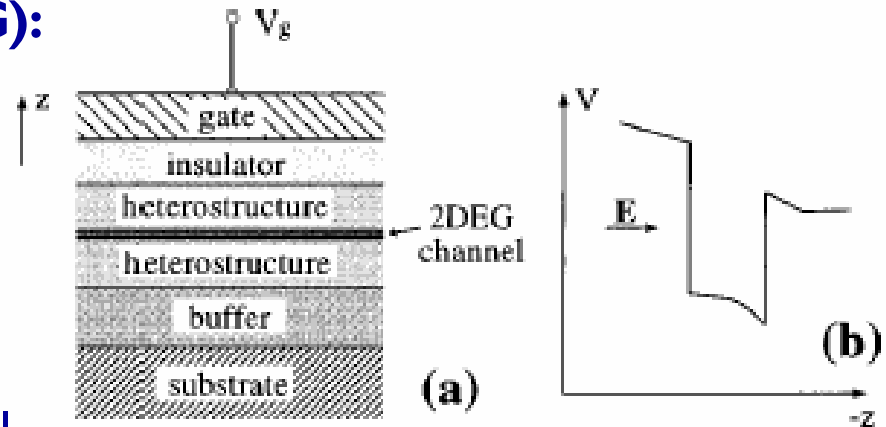
Rashba Effect

■ Two dimensional electron gas (2DEG):

- $n_s \sim 10^{12} \text{ cm}^{-2}$, $v_F \sim 10^7 \text{ cm/sec}$
- weakly relativistic

■ Perpendicular electrical field:

- due to asymmetry of confining potential
- due to gate voltage



M. Johnson, Phys. Rev. B **58**, 9635 (1998)

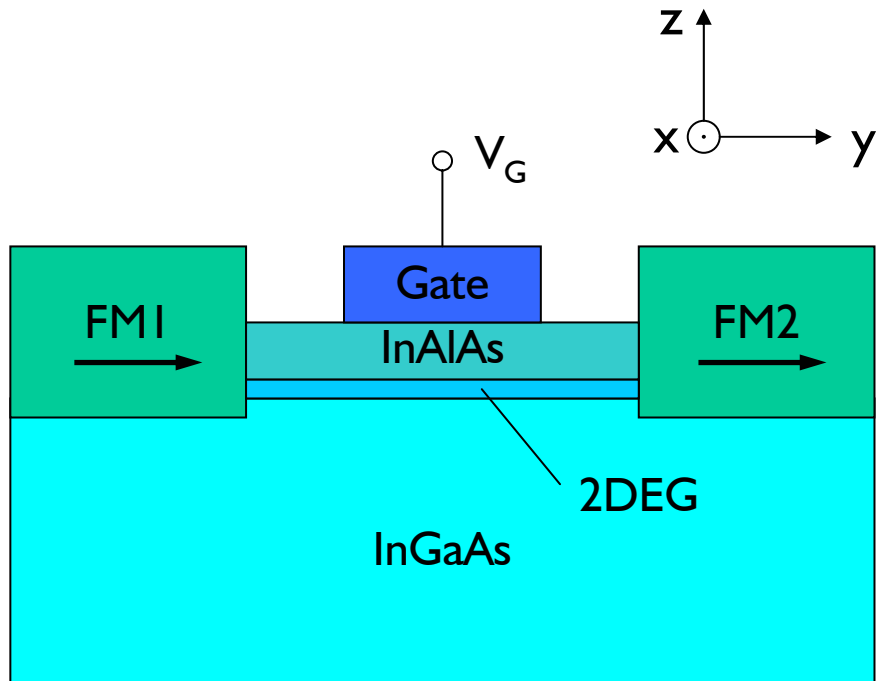
■ Perpendicular electrical field transforms to a magnetic field H^*

- conduction band electron spin degeneracy is lifted

■ Spin-orbit Hamiltonian:

- $H_{SO} = \alpha (\boldsymbol{\sigma} \times \mathbf{k}) \cdot \mathbf{z}$
- Yu. A. Bychkov and E. I. Rashba, J. Phys. C **17**, 6039 (1984).

Datta-Das Spin Transistor



S. Datta and B. Das, Appl. Phys. Lett. **56**, 665 (1990)

■ Generation

- ferromagnetic (FM) contact FMI

■ Transportation

- from FMI into 2DEG

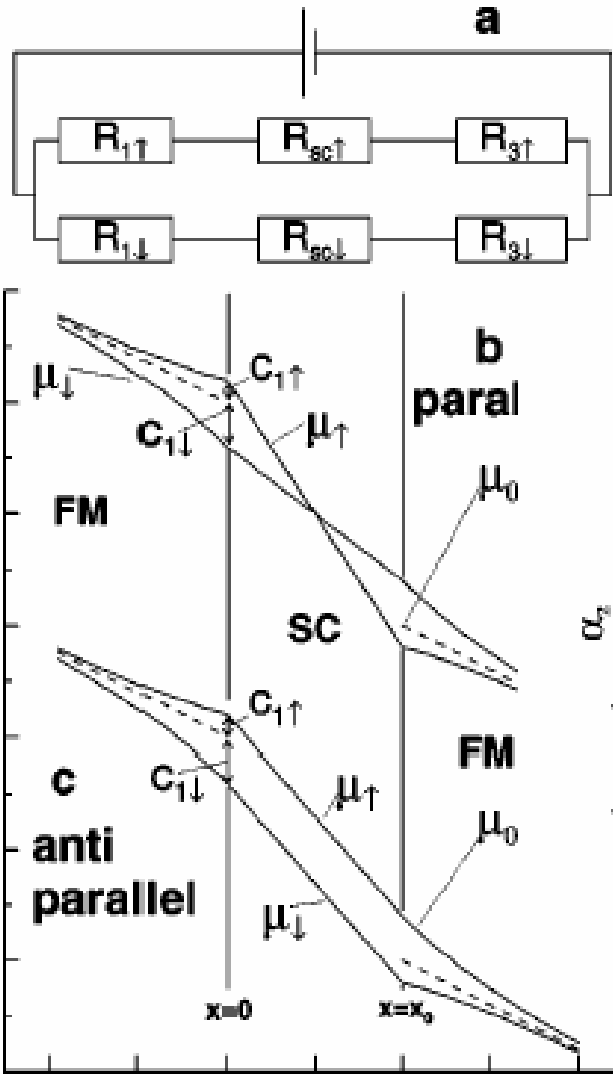
■ Manipulation

- Rashba effect: $H_{SO} = \alpha (\boldsymbol{\sigma} \times \mathbf{k}) \cdot \mathbf{z}$
- gate voltage controls α

■ Detection

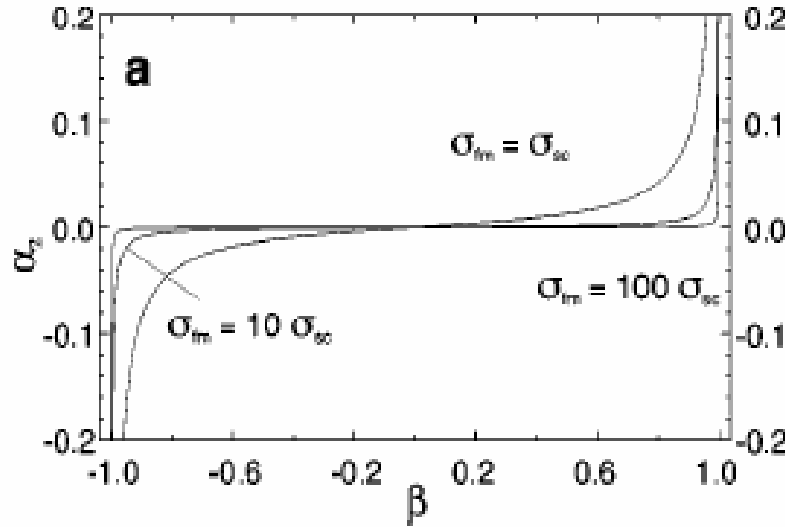
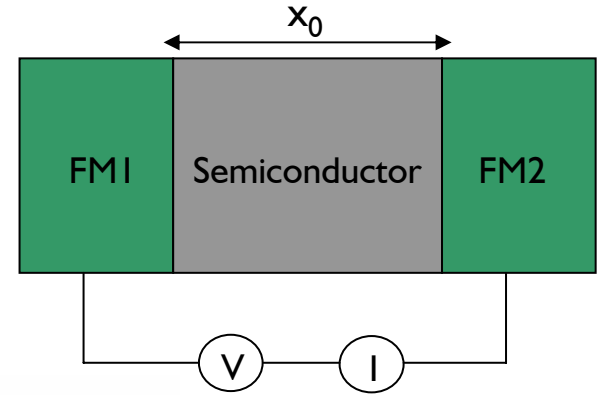
- ferromagnetic contact FM2

Conductivity Mismatch



Chemical potential μ

$$\frac{\partial \mu_{\uparrow, \downarrow}}{\partial x} = - \frac{e j_{\uparrow, \downarrow}}{\sigma_{\uparrow, \downarrow}}$$



α_2 – current polarization in parallel alignment

β – spin polarization of FM metals

λ_{FM} – spin decay length in FM metal

Resistance model:

$$R_{SC} = x_0 / \sigma_{SC}$$

$$R_{FM} = \lambda_{FM} / \sigma_{FM}$$

Normally,

$$x_0 > \lambda_{FM}$$

$$\sigma_{SC} \ll \sigma_{FM}$$

then,

$$R_{FM} \ll R_{SC}$$

Solution: Tunnel Barrier

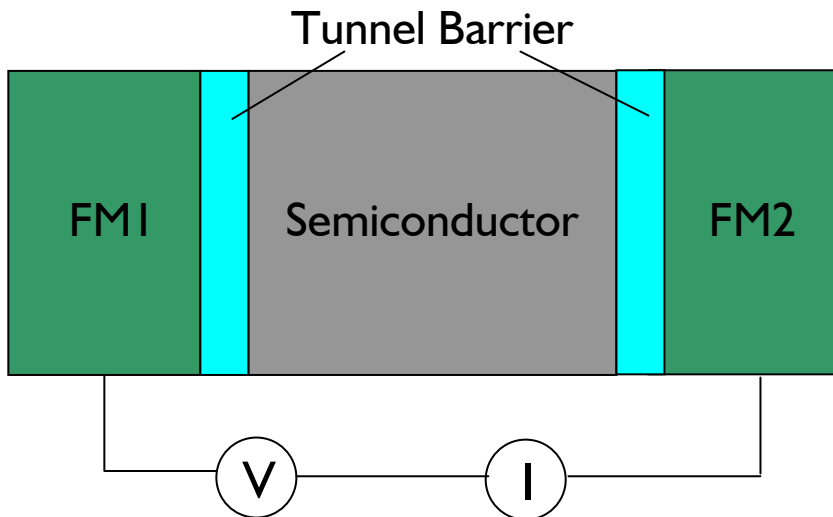
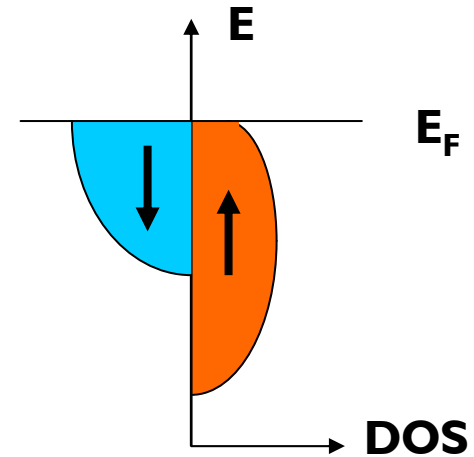
■ Tunneling current:

$$J = e \sum_{q,k} \frac{2\pi}{\hbar} |T_{q,k}|^2 [f_k(1-f_q) - f_q(1-f_k)]$$

q, k: initial and final states

f: Fermi distribution function

T: tunneling matrix element



■ FM metal electrode: density of states (DOS) is spin polarized

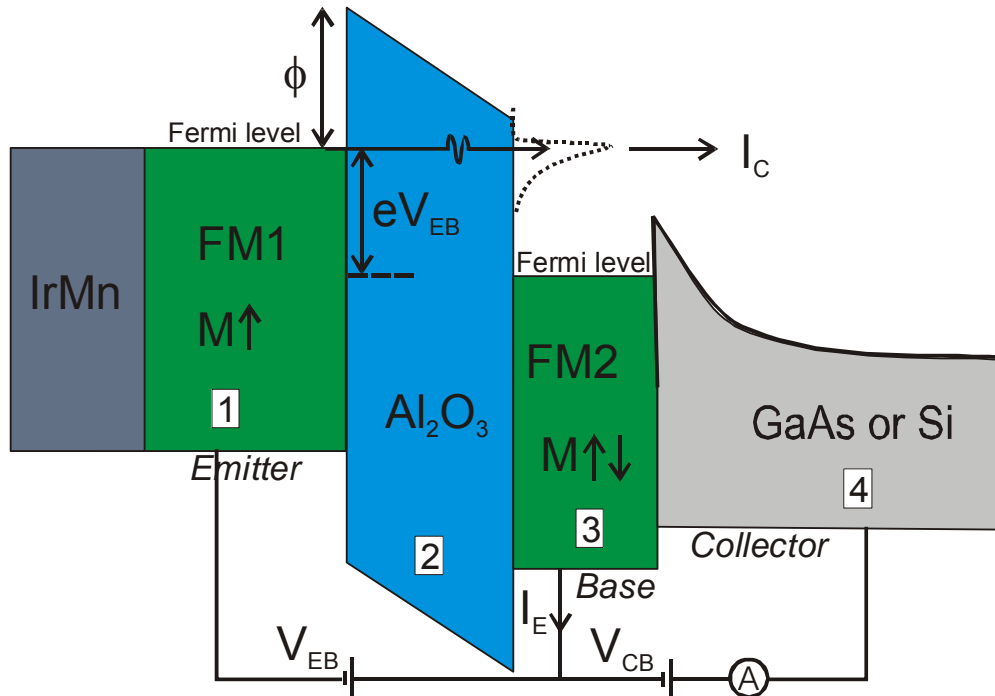
→ tunnel barrier conductance is spin dependent

■ The presence of tunnel barrier can enhance spin injection efficiency

- E. I. Rashba, Phys. Rev. B **62**, R16267 (2000).

- V. Ya. Kravchenko and E. I. Rashba, Phys. Rev. B **67**, 121310 (R) (2003)

Magnetic Tunnel Transistor (MTT) with a Single Base Layer



■ Emitter (FM1):

- Injects spin-polarized hot electrons into the base

■ Base (FM2):

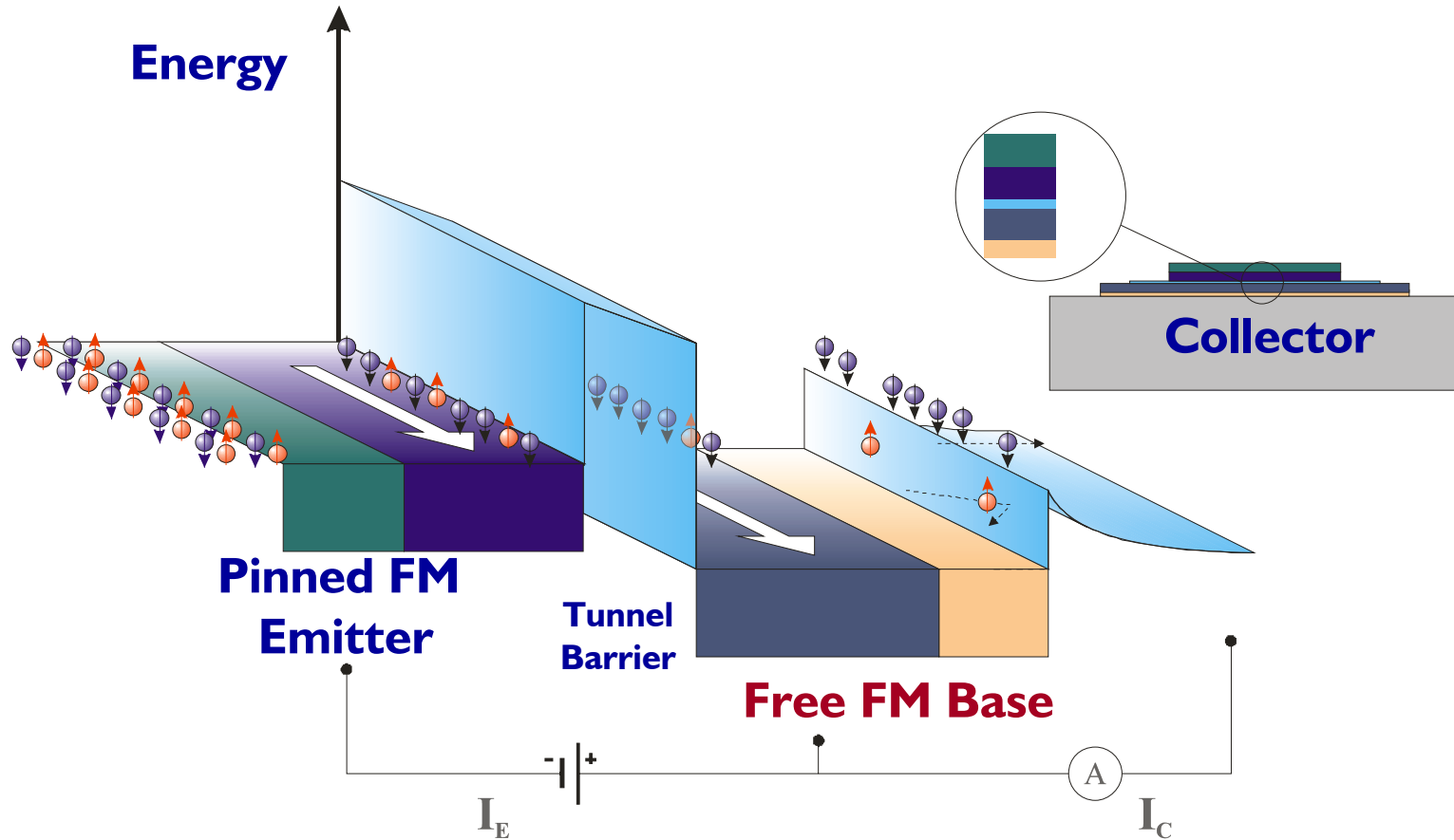
- Spin-dependent scattering
- Serves as a spin filter

■ Collector (GaAs):

- Schottky barrier at the interface
- Only collects electrons when they have enough energy to overcome the Schottky barrier and when there are states available in the semiconductor.

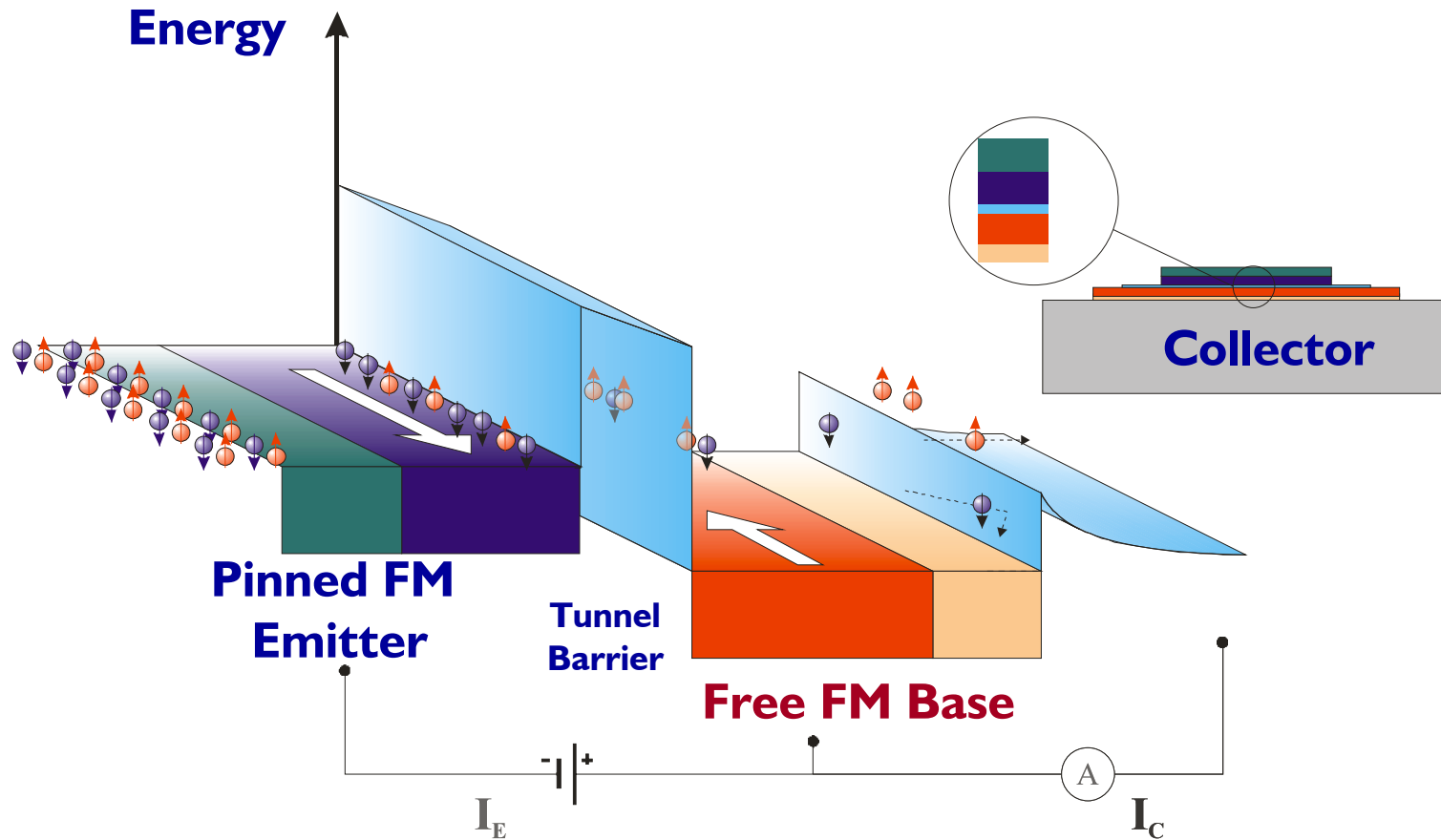
MTT- Parallel Ferromagnetic Moments

FM Moments Parallel



MTT- Anti-Parallel FM Moments

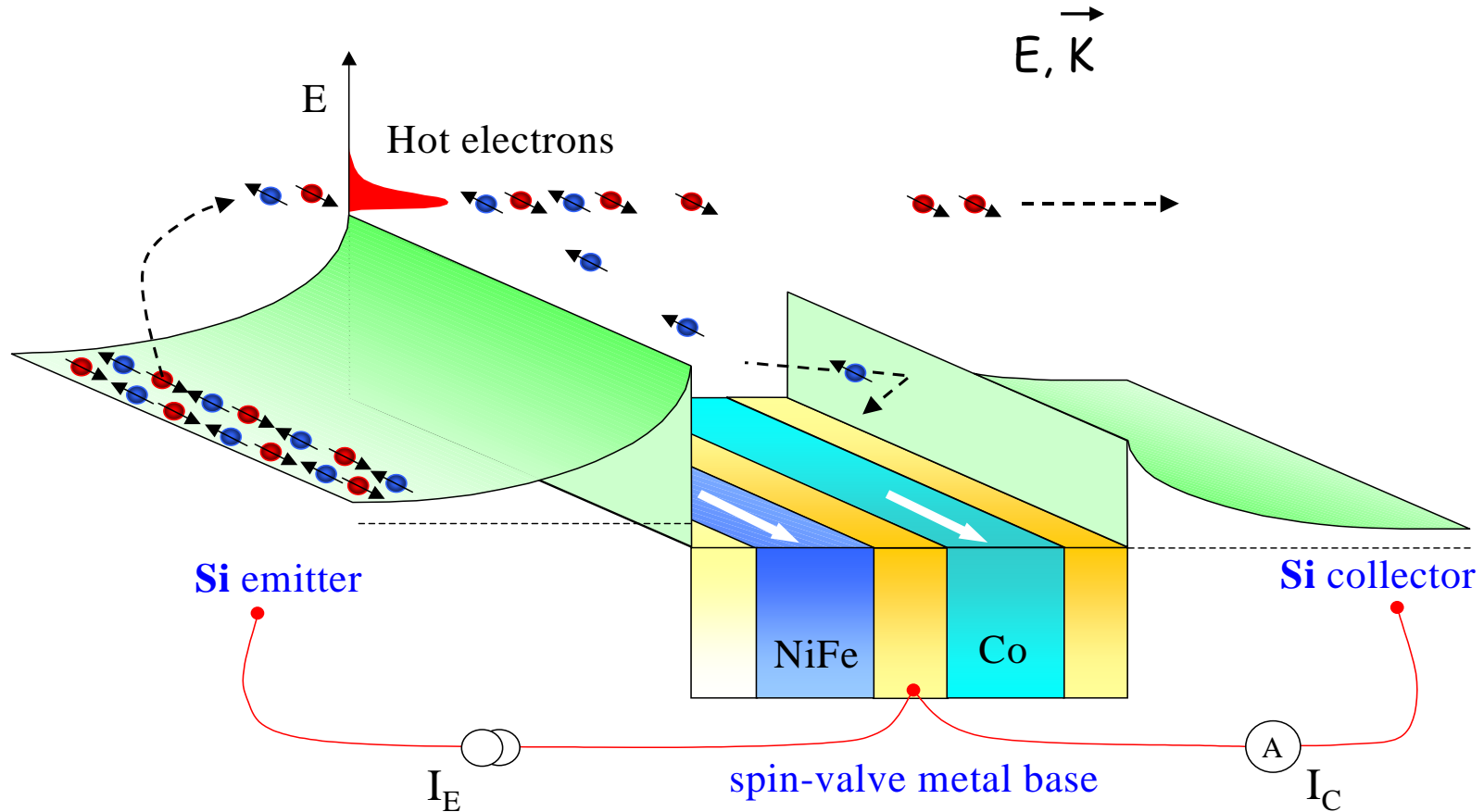
FM Moments Anti-Parallel



Spin Valve Transistor (SVT)

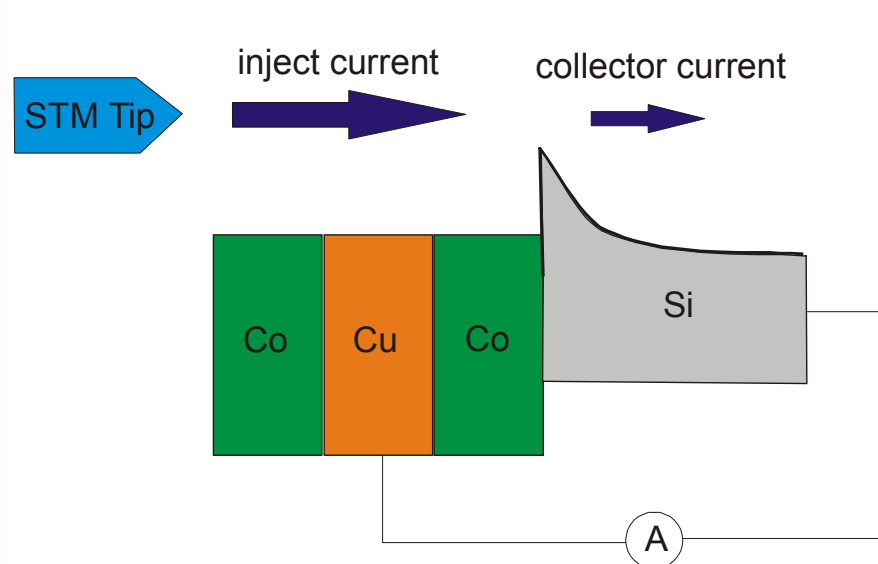
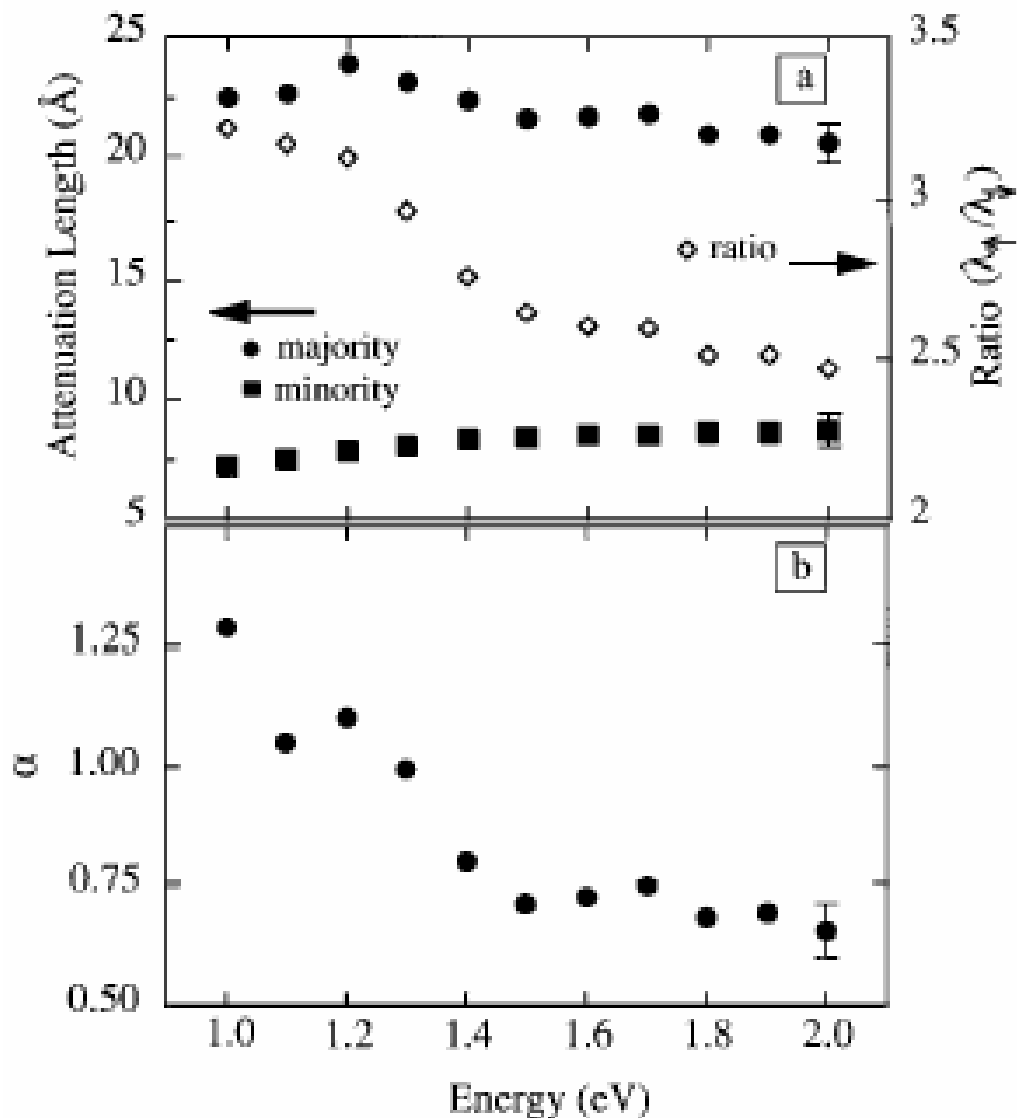
Monsma et al. (1995); Jansen et al. (2000)

Maximum MC observed $\sim 560\%$ at 80 K



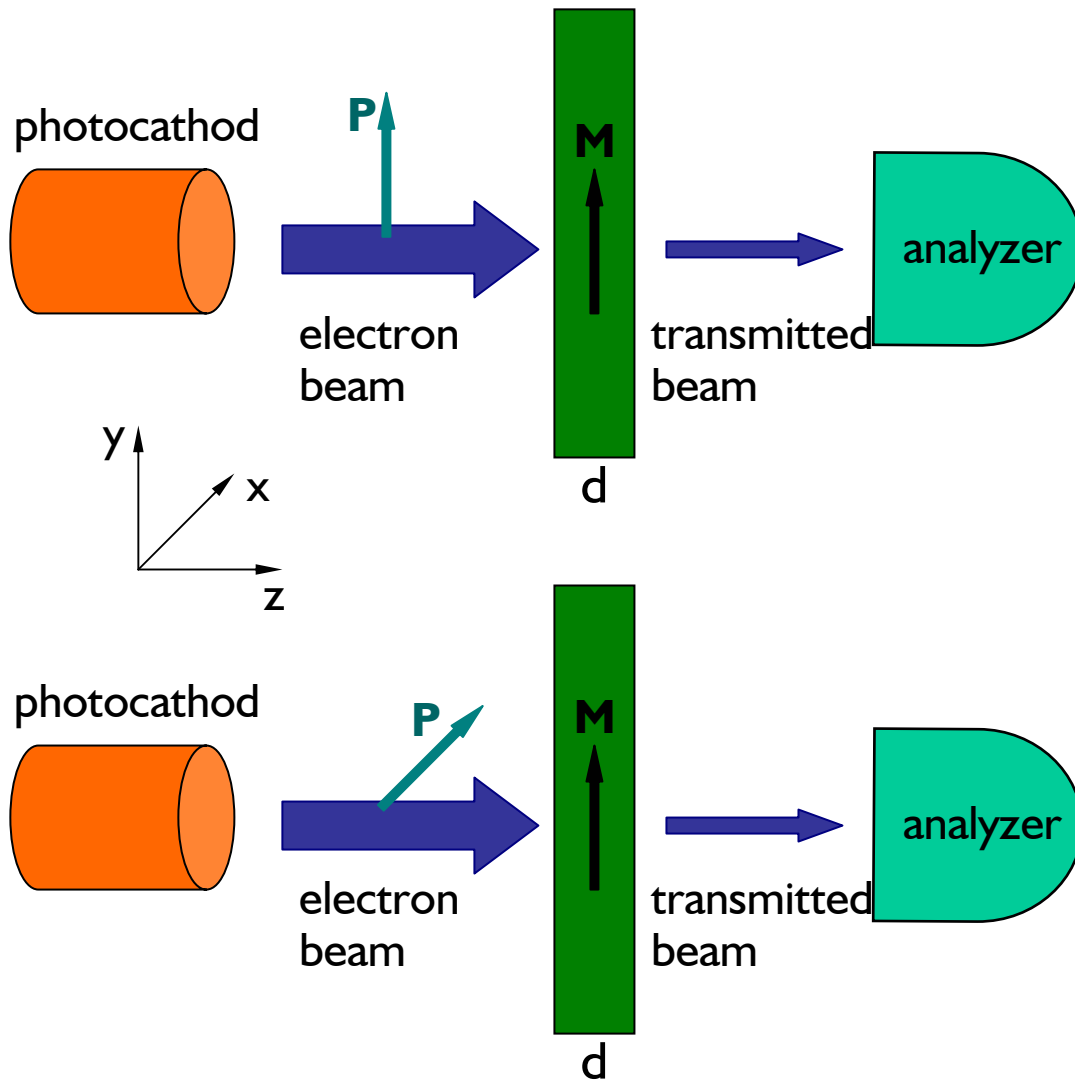
- Hot electron energy is limited by emitter Schottky barrier height.
- Collector current is very small (~ 20 nA)

Ballistic Electron Magnetic Microscopy (BEMM)



- Electrons injected from an STM tip
- Study spin-dependent hot electron transport in FM thin films

Spin-Resolved Electron Transmission through FM Thin Films



- **Electrons generated by photocathode**
- **Electron polarization parallel to FM film magnetization**
 - study spin-dependent electron transmission through FM thin films
- **Polarization perpendicular to magnetization**
 - spin transfer
 - M and P precess about **each other**
 - current induced magnetization reversal

D. Oberli, R. Burgermeister, S. Riesen, W. Weber, and H. C. Siegmann, Phys. Rev. Lett. **81**, 4228 (1998).

W. Weber, S. Riesen, and H. C. Siegmann, Science **291**, 1015 (2000).

Magnetic Tunnel Transistor

Magnetic tunnel transistor:

- Advantages:

solid state device

high spin polarization ($> 95\%$)

room temperature operation

use tunnel barrier \rightarrow no conductivity mismatch problem

electron energy can be adjusted by bias voltage: $\sim 0.8 - 2.5$ eV

high speed

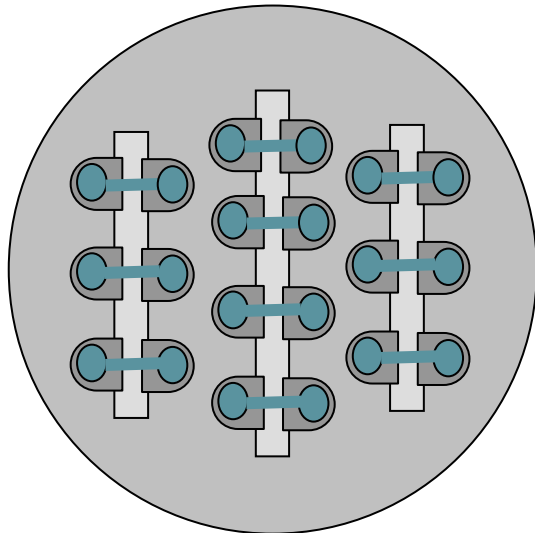
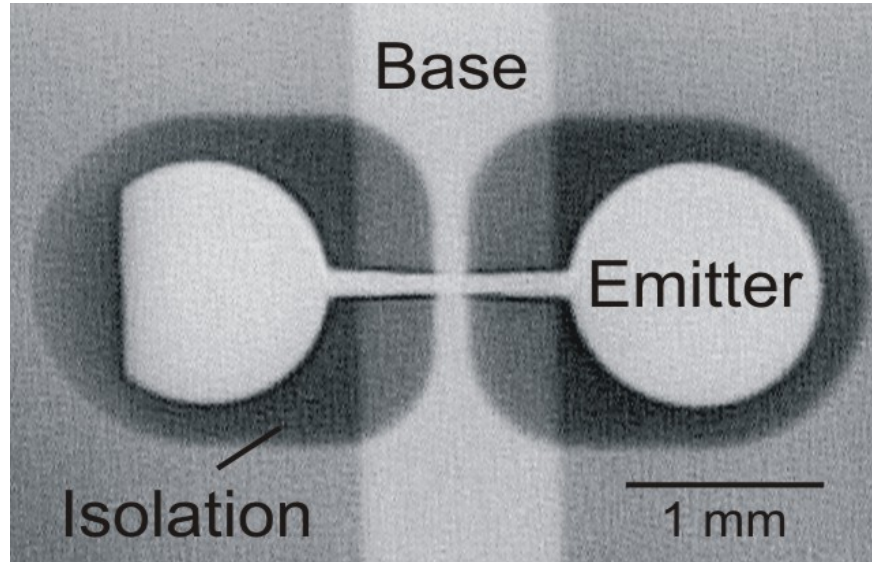
- Disadvantage:

small collector current

\rightarrow increase transfer ratio by reducing interface scattering

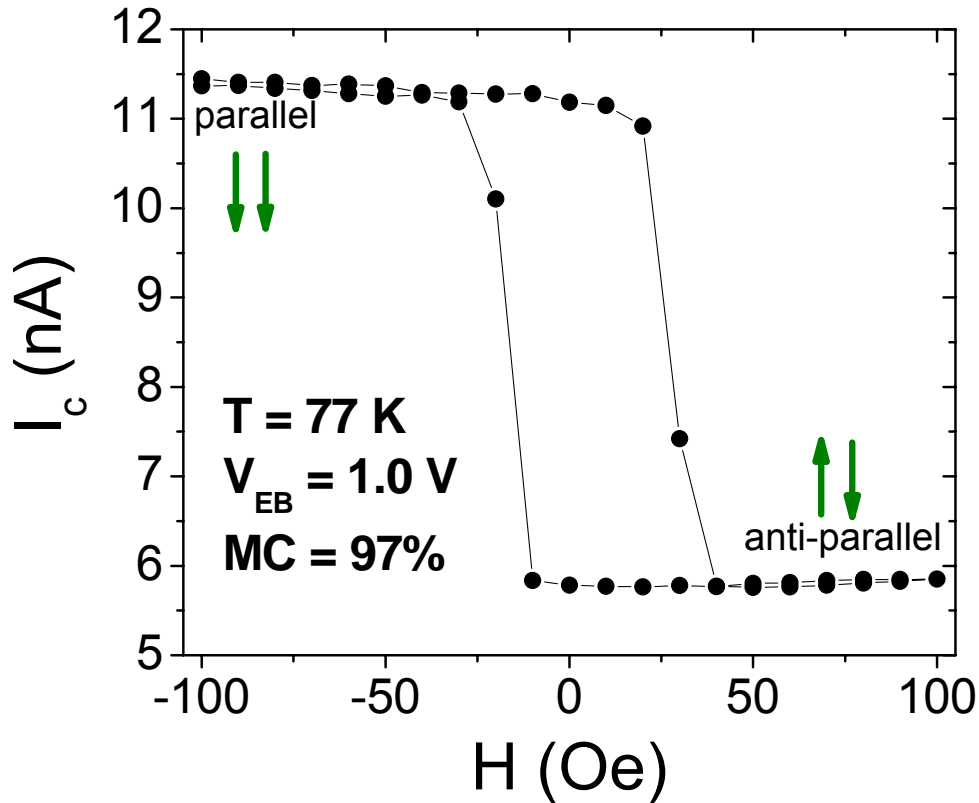
\rightarrow reduce tunnel barrier resistance

Fabrication of Magnetic Tunnel Transistors



- Magnetron sputtering and ion-beam sputtering at room temperature
- Three shadow masks
- Active junction area $\sim 100 \times 300 \text{ nm}^2$
- Base area $\sim 1 \times 8 \text{ mm}^2$

Magnetocurrent (MC) and Transfer Ratio (TR)



■ Magnetocurrent (MC):

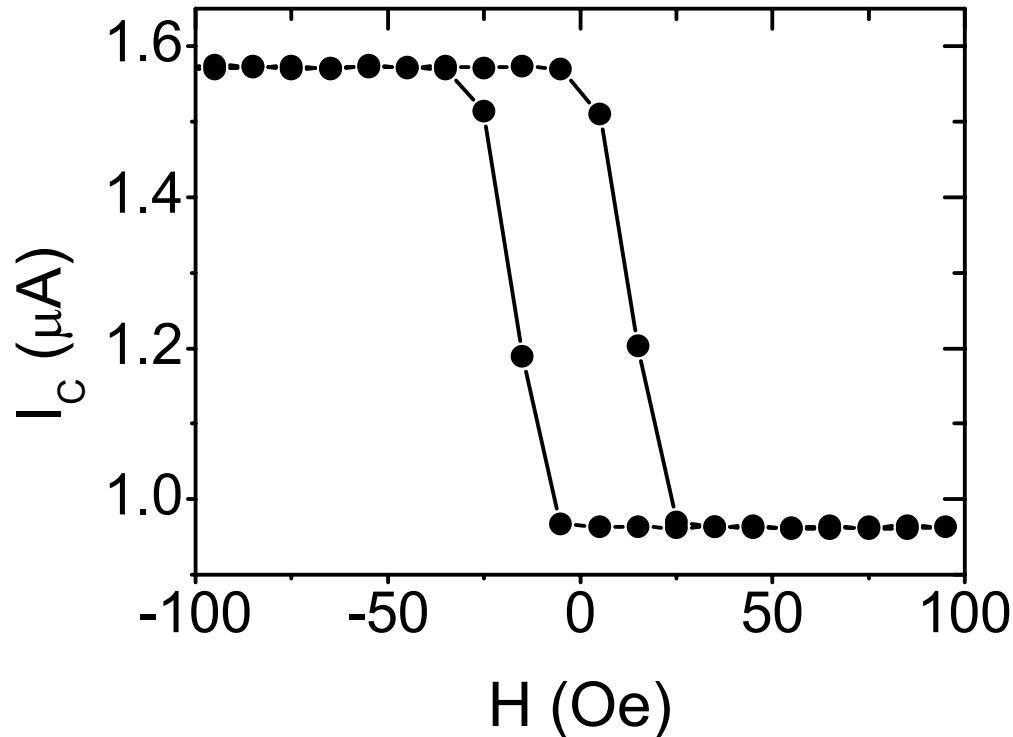
$$MC = \frac{I_{C,P} - I_{C,AP}}{I_{C,AP}}$$

■ Transfer Ratio (TR):

$$TR = \frac{I_C}{I_E}$$

GaAs (111) / 30 Å $\text{Co}_{84}\text{Fe}_{16}$ / 26 Å Al_2O_3 / 50 Å
 $\text{Co}_{84}\text{Fe}_{16}$ / 300 Å $\text{Ir}_{22}\text{Mn}_{78}$ / 50 Å Ta

Room Temperature Operation



■ $MC = 64\%$ ($V_{EB} = 1.4 \text{ V}$)

■ $I_{C,P} \sim 1.6 \mu\text{A}$

■ MC limited by leakage current from the Schottky barrier

$$I'_{C,P} = I_{C,P} + I_{LEAK}$$

$$I'_{C,AP} = I_{C,AP} + I_{LEAK}$$

$$MC' = (I'_{C,P} - I'_{C,AP}) / I'_{C,AP}$$

$$= (I_{C,P} - I_{C,AP}) / (I_{C,AP} + I_{LEAK})$$

$$= MC / (1 + I_{LEAK} / I_{C,AP})$$

■ Leakage current can be greatly reduced by making MTTs with small base area

Collector Current

■ MTT structure:

Emitter → 50 Å $\text{Co}_{84}\text{Fe}_{16}$ / 25 Å Al_2O_3

Base → t $\text{Ni}_{81}\text{Fe}_{19}$ (25 – 100 Å)

Collector → GaAs (001)

■ Collector current:

$$I_{C,P(AP)} = I_E \left(\frac{1 + P_E}{2} \right) e^{-t/\lambda_{\uparrow(\downarrow)}} \alpha_{\uparrow(\downarrow)} + I_E \left(\frac{1 - P_E}{2} \right) e^{-t/\lambda_{\downarrow(\uparrow)}} \alpha_{\downarrow(\uparrow)}$$

$I_{C,P(AP)}$: collector current in parallel (anti-parallel) alignment

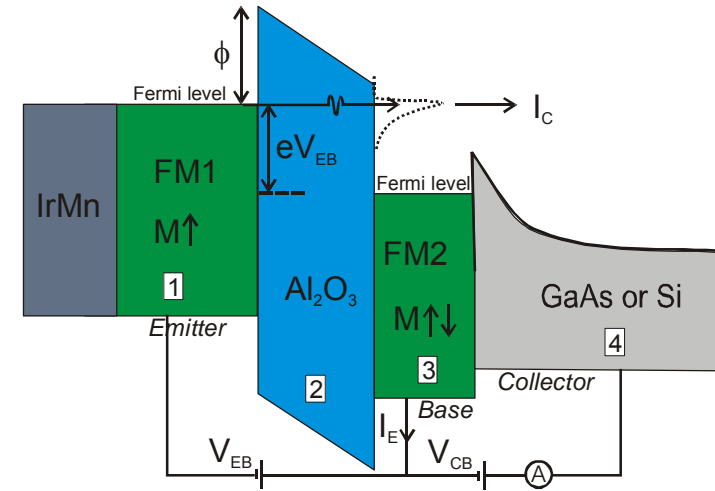
I_E : emitter current

P_E : spin polarization in the emitter

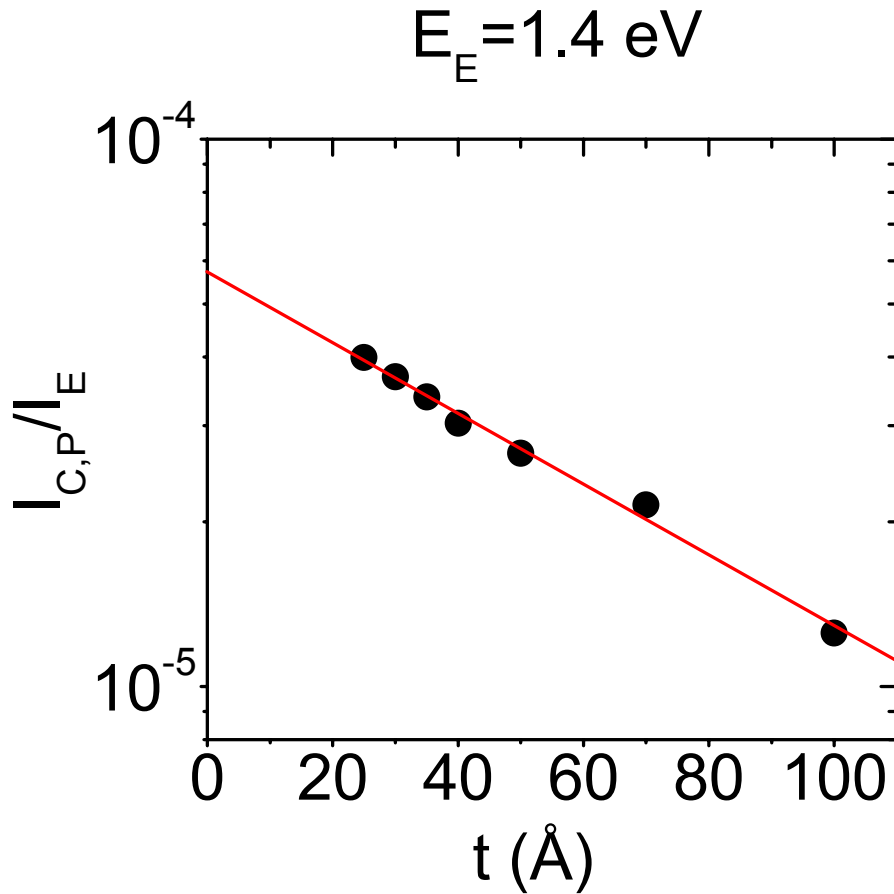
t : base layer thickness

$\lambda_{\uparrow(\downarrow)}$: attenuation length of majority (minority) spins in the base

$\alpha_{\uparrow(\downarrow)}$: **collection** efficiency at the interface for majority (minority) spins



Majority Electron Attenuation Length



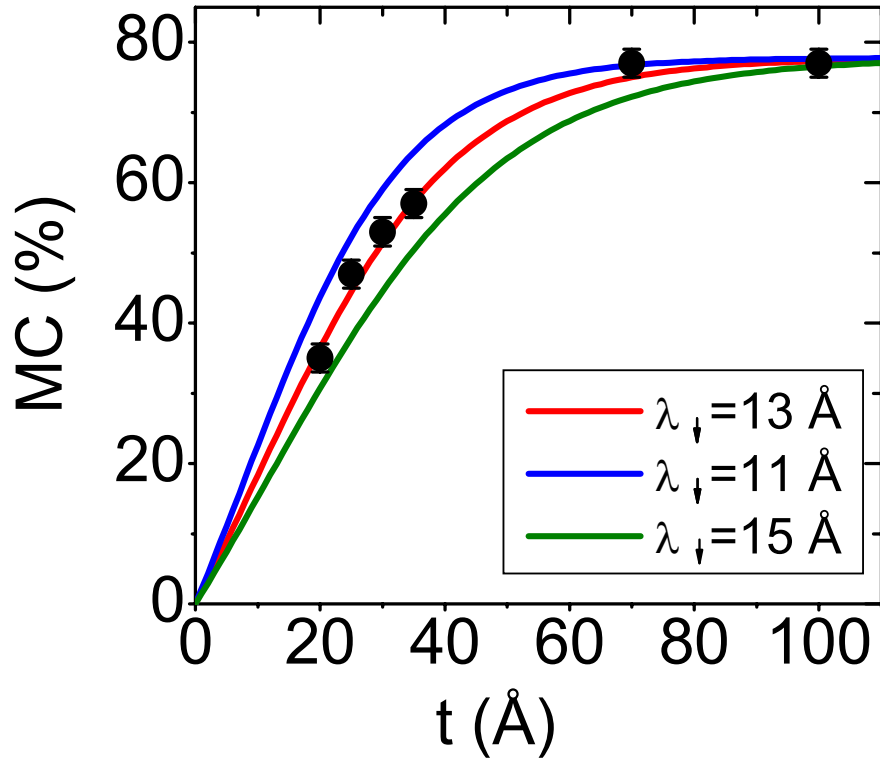
In parallel alignment, transport of minority spins is negligible for thick films:

$$I_{C,P} / I_E \propto e^{-t/\lambda_{\uparrow}}$$

Fit: $\lambda_{\uparrow} = 67 \pm 3 \text{ \AA}$

Minority Electron Attenuation Length

$$E_E = 1.4 \text{ eV}$$



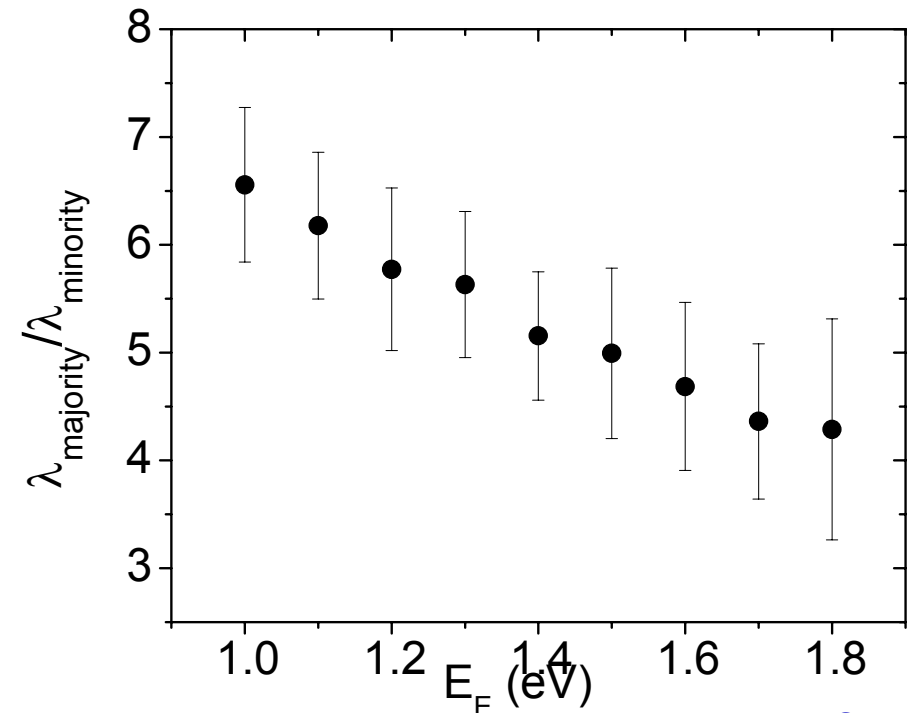
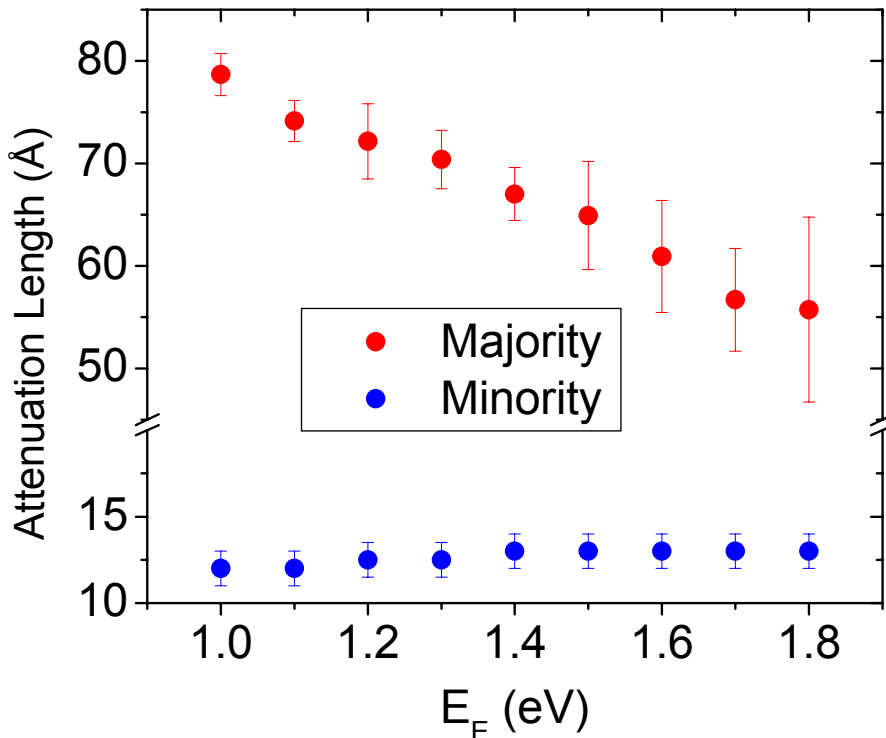
Spin-dependence of interface scattering is negligible.

Fit: $\lambda_{\downarrow} = 13 \pm 2 \text{ \AA}$

Energy Dependence of Attenuation Length: NiFe

- Attenuation length of majority electrons decreases with electron energy.
- Attenuation length of minority electrons does not change much.
- Can be explained by strong electron-electron scattering.

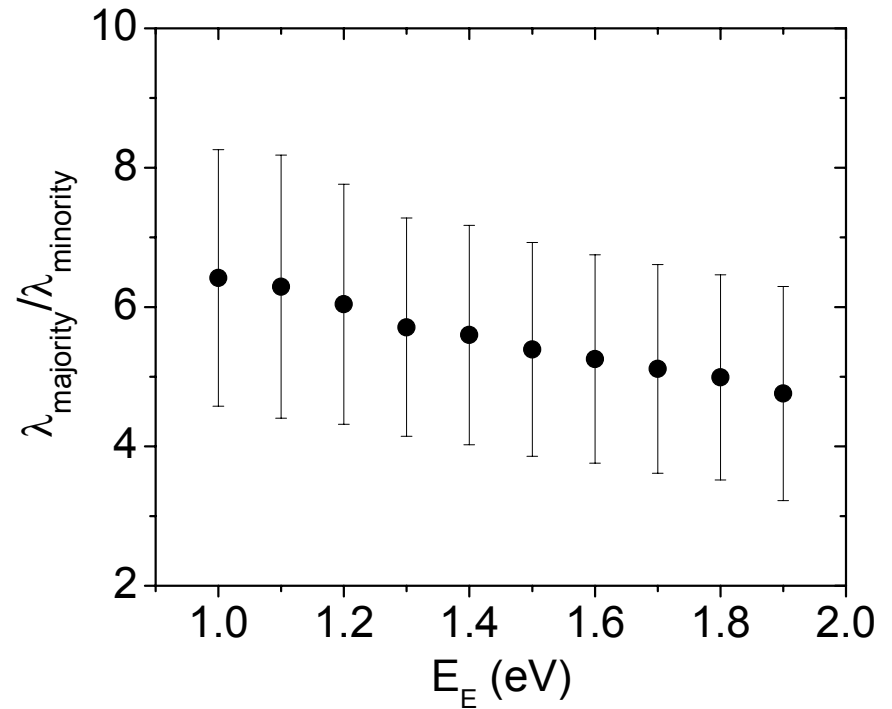
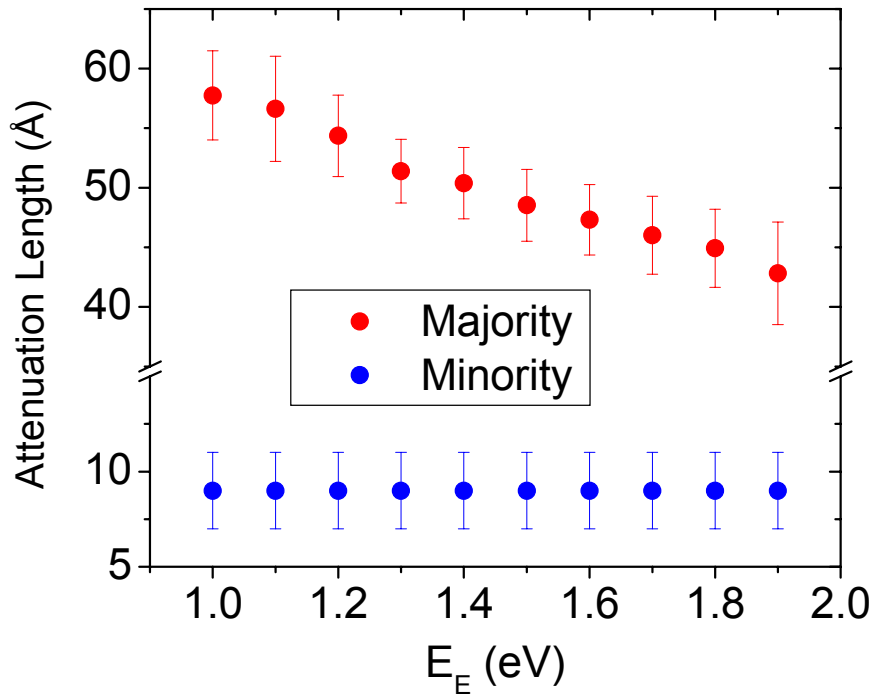
$\text{Ni}_{81}\text{Fe}_{19}$ ($T=77\text{ K}$)



Energy Dependence of Attenuation Length: CoFe

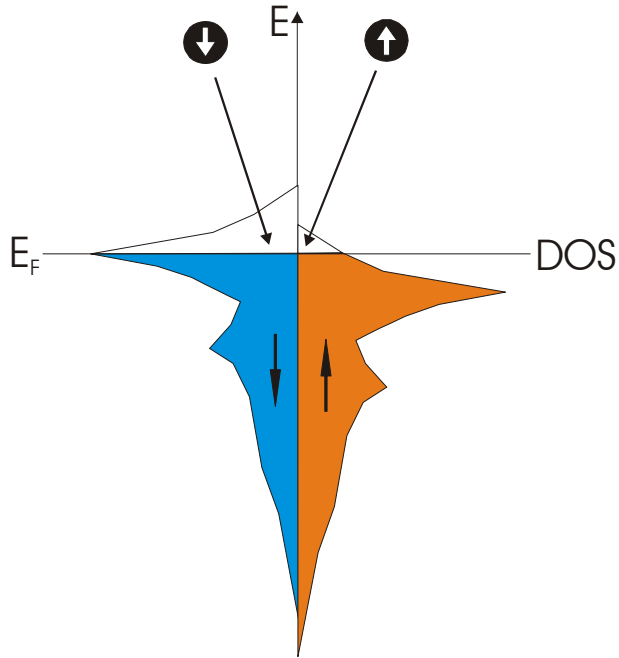
- Similar result for $\text{Co}_{84}\text{Fe}_{16}$ thin films.

$\text{Co}_{84}\text{Fe}_{16}$ (T=77 K)

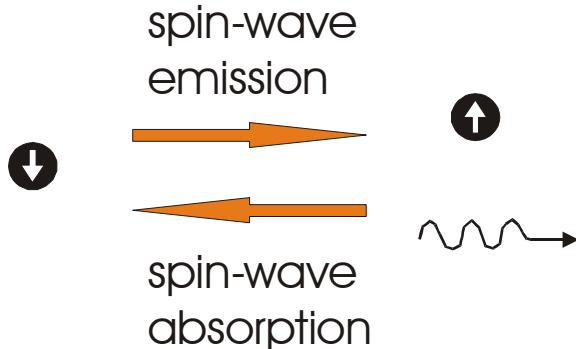


Electron Scattering in FM 3d Transition Metals

electron-electron scattering



Spin-wave scattering



■ Electron-electron scattering

- spin asymmetry in the DOS of d band
- minority electrons are strongly scattered due to the abundance of unoccupied states to scatter into

■ Spin-dependent elastic scattering

- due to exchange coupling of electron spins to the magnetic moments of ions

■ Spontaneous spin-wave emission

- only scatters minority electrons due to angular momentum conservation restraint

■ Thermal spin-wave scattering

- causes spin-mixing

■ Phonon scattering

- no significant spin-dependence

References for Electron Scattering Mechanisms

J. J. Quinn, Phys. Rev. **126**, 1453 (1962).

R. K. Nesbet, Phys. Rev. B **32**, 390 (1985).

A. Ormeci, B. M. Hall, and D. L. Mills, Phys. Rev. B **42**, 4524 (1990).

D. P. Pappas et al., Phys. Rev. Lett. **66**, 504 (1991).

M. P. Gokhale and D. L. Mills, Phys. Rev. Lett. **66**, 2251 (1991).

G. Schönhense and H. C. Siegmann, Ann. Phys. (Leipzig) **2**, 465 (1993).

M. Plihal, D. L. Mills, and J. Kirschner, Phys. Rev. Lett. **82**, 2579 (1999).

J. Hong and D. L. Mills, Phys. Rev. B **59**, 13840 (1999).

E. Zarate, P. Apell, and P. M. Echenique, Phys. Rev. B **60**, 2326 (1999).

R. Jansen et al., Phys. Rev. Lett. **85**, 3277 (2000).

R. Knorren et al., Phys. Rev. B **61**, 9427 (2000).

H. -J. Drouhin, Phys. Rev. B **62**, 556 (2000).

H.-J. Drouhin, J. Appl. Phys. **89**, 6805 (2001).

Energy Dependence of Majority Electron Attenuation Length

According to the conventional Fermi liquid theory*, relaxation time due to electron-electron scattering is:

$$\tau \propto 1/E_E^2$$

Then attenuation length is:

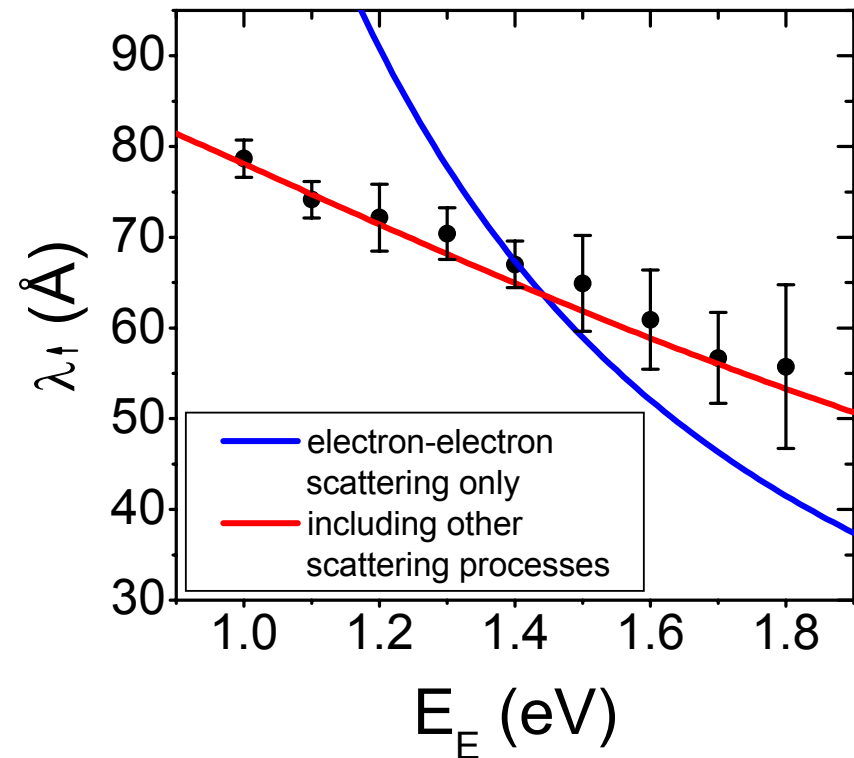
$$\lambda \propto v \tau \propto (E_E + E_F)^{1/2}/E_E^2$$

Including other scattering processes:

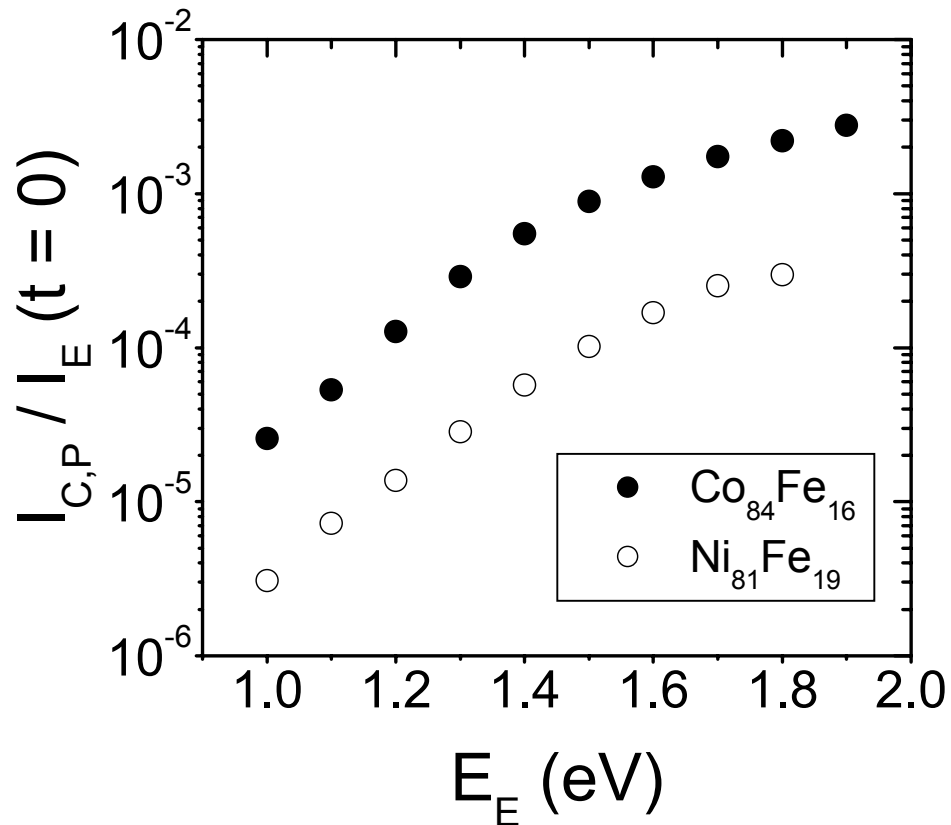
$$1/\lambda = 1/\lambda_{\text{el-el}} + 1/\lambda_{\text{other}}$$

(assuming λ_{other} is independent of electron energy).

*J. J. Quinn, Phys. Rev. **126**, 1453 (1962)

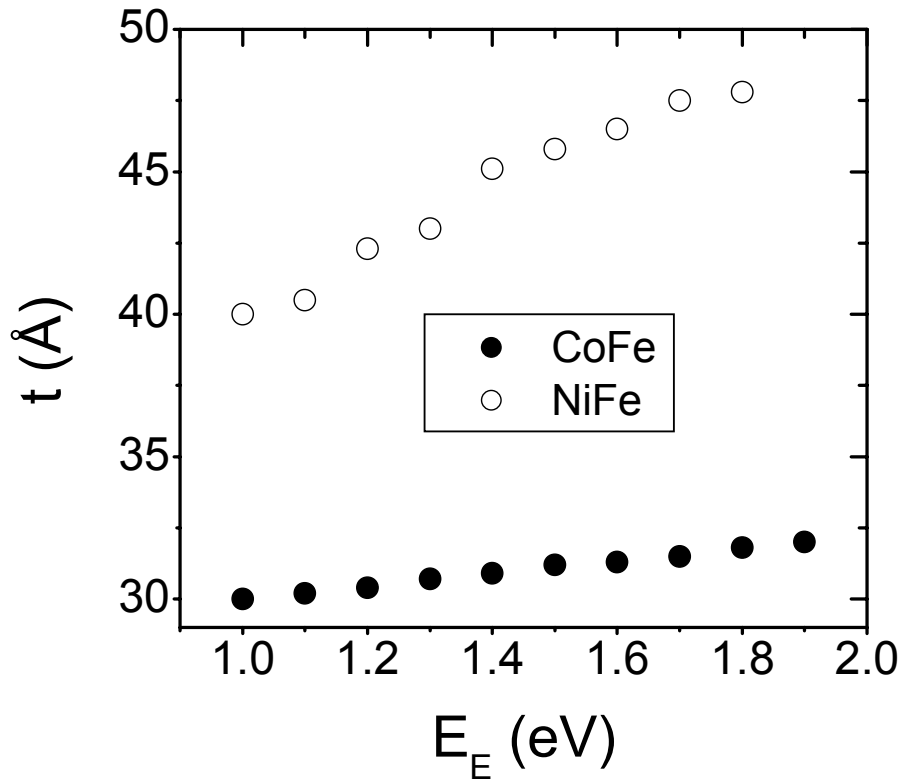


Interface Scattering: CoFe vs. NiFe



- Extrapolated transfer ratio at zero base layer thickness for parallel alignment.
- Stronger interface scattering for NiFe/GaAs than for CoFe/GaAs.
- Transfer ratio can be improved by minimizing interface scattering

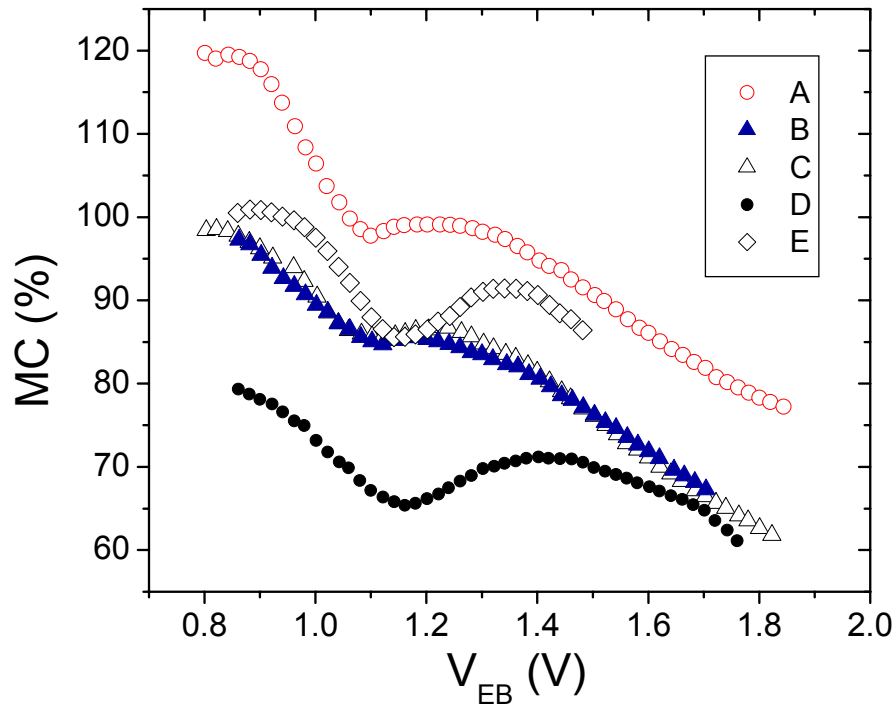
Spin Polarization vs. Base Layer Thickness



- Required base layer thickness in order to obtain 95% spin-polarized current.
- Emitter polarization is assumed to be 40%.
- MTT promises a highly spin-polarized electron source at room temperature.

Bias Dependence of MC in MTTs with GaAs Collectors

MTT structure: Collector / Base / $\sim 20 \text{ \AA}$ Al_2O_3 / 50 \AA CoFe / 300 \AA IrMn / 50 \AA Ta

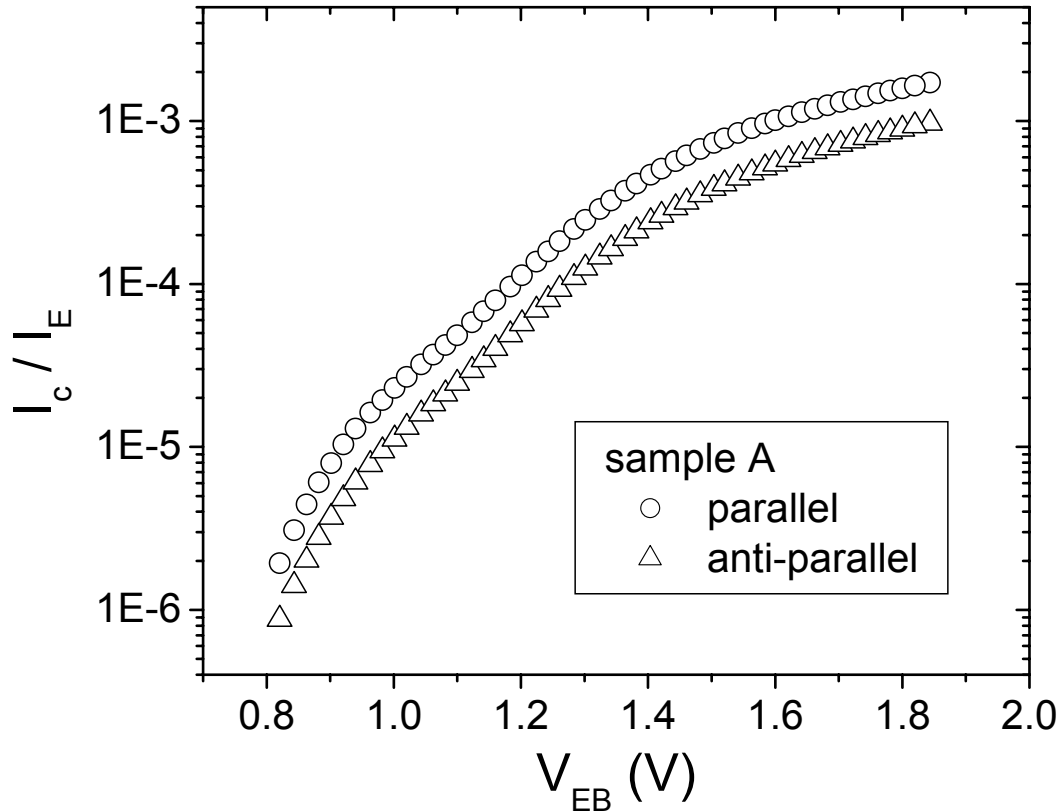


Sample	Base	Collector	TMR (%)
A	30 Å CoFe	GaAs(001)	46.4
B	45 Å CoFe	GaAs(001)	40.7
C	100 Å CoFe	GaAs(001)	31.7
D	74 Å NiFe	GaAs(001)	14.7
E	30 Å CoFe	GaAs(111)	29.0

Sample A:

- MC decreases monotonically with bias up to $\sim 1.1 \text{ V}$
- MC increases after 1.1 V and then decreases gradually at higher bias

Bias Dependence of Transfer Ratio



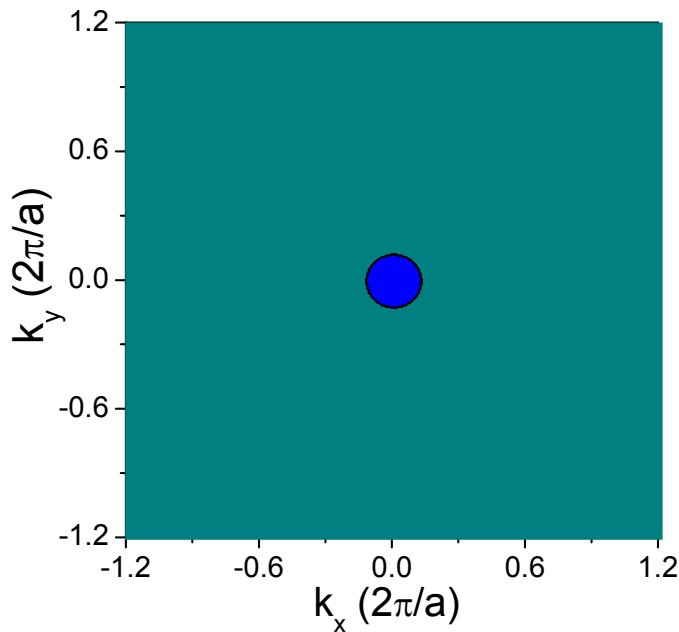
- Transfer ratio increases with bias due to the opening of GaAs conduction bands for electron collection.
- More rapid increase in transfer ratio at ~ 1.1 V.

GaAs Conduction Band Structure

Γ band:

→ lowest energy

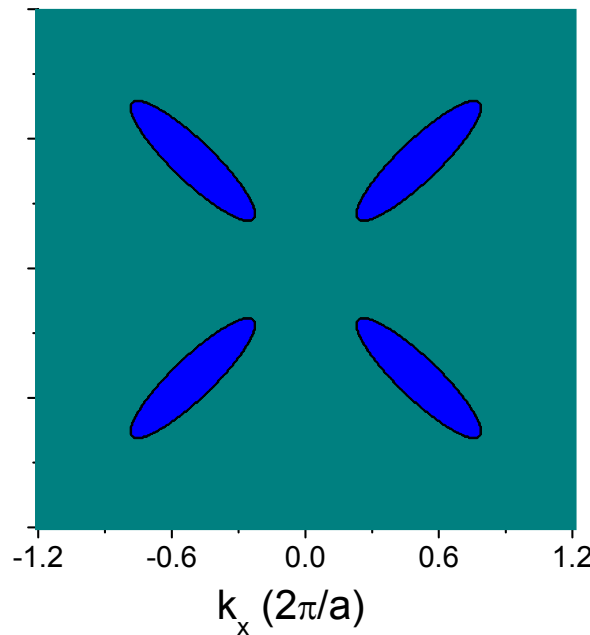
Γ Band



L bands:

→ 0.29 eV above Γ band

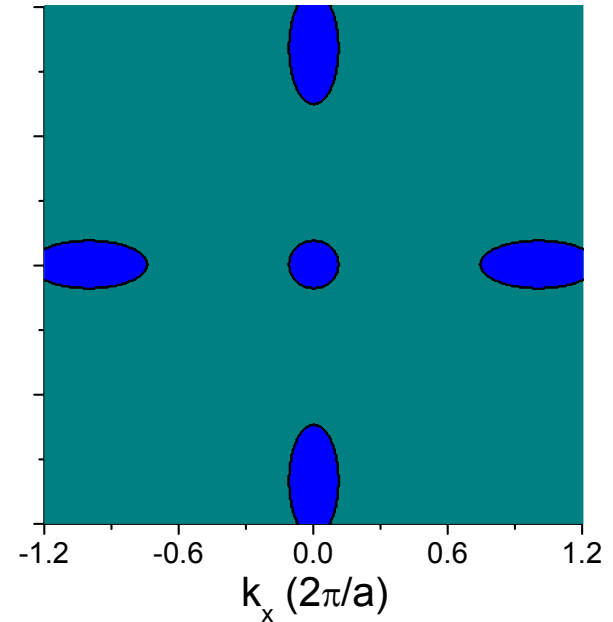
L Bands



X bands:

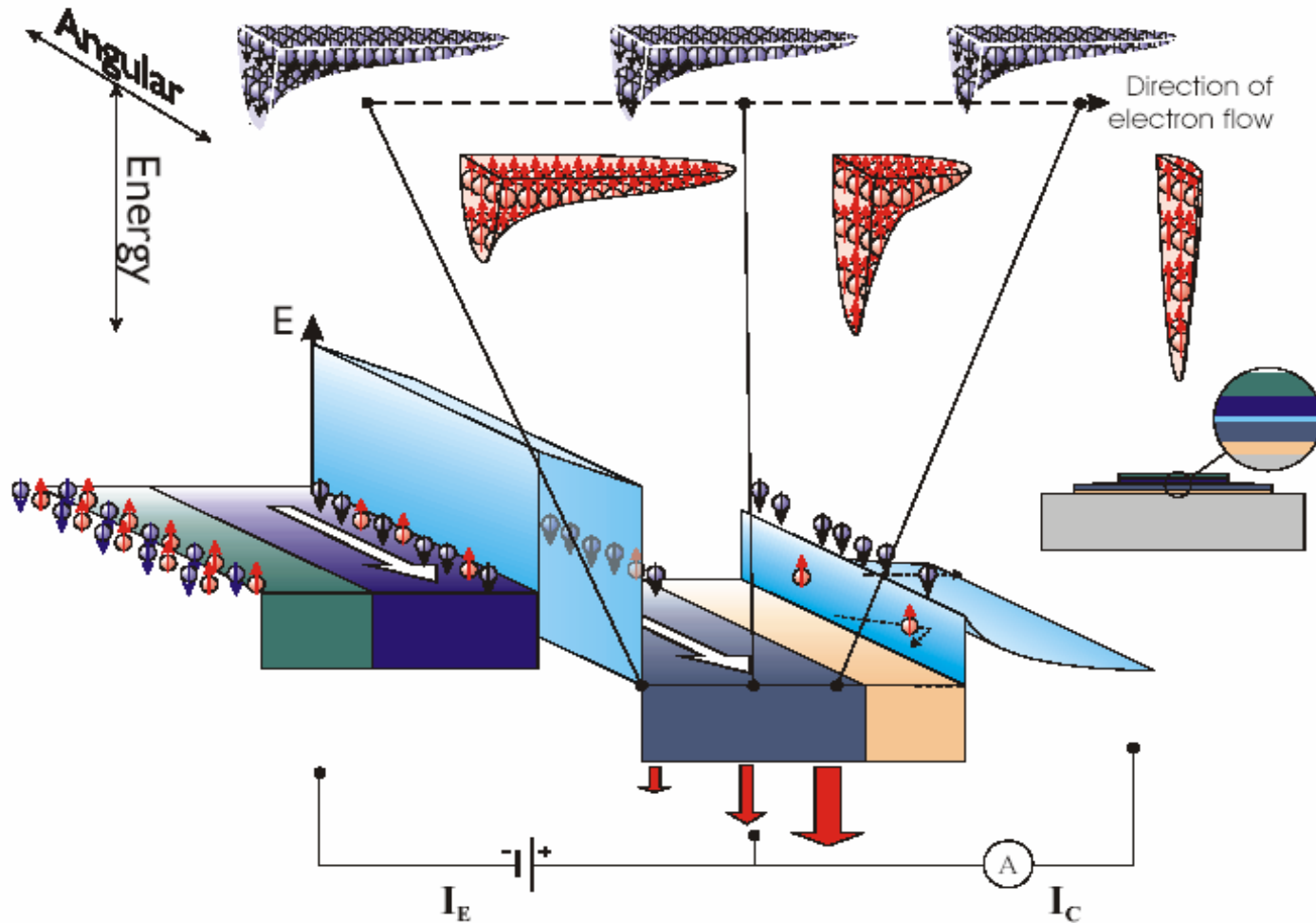
→ 0.48 eV above Γ band

X Bands



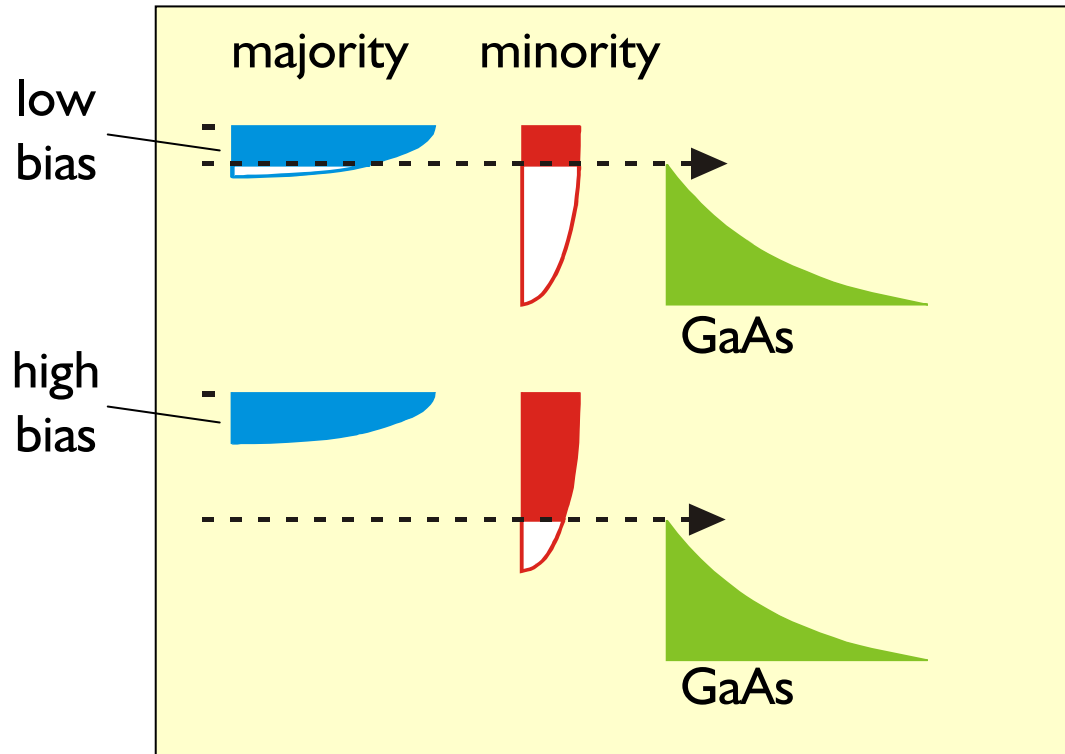
Projection of GaAs energy bands on (001) plane

Energy and Angular Distribution of Hot Electrons



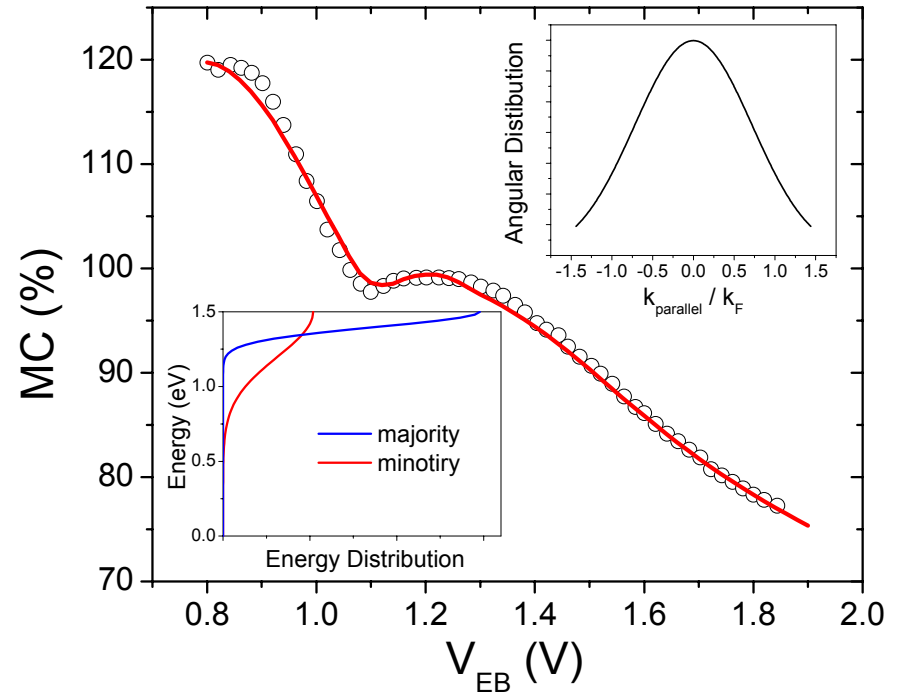
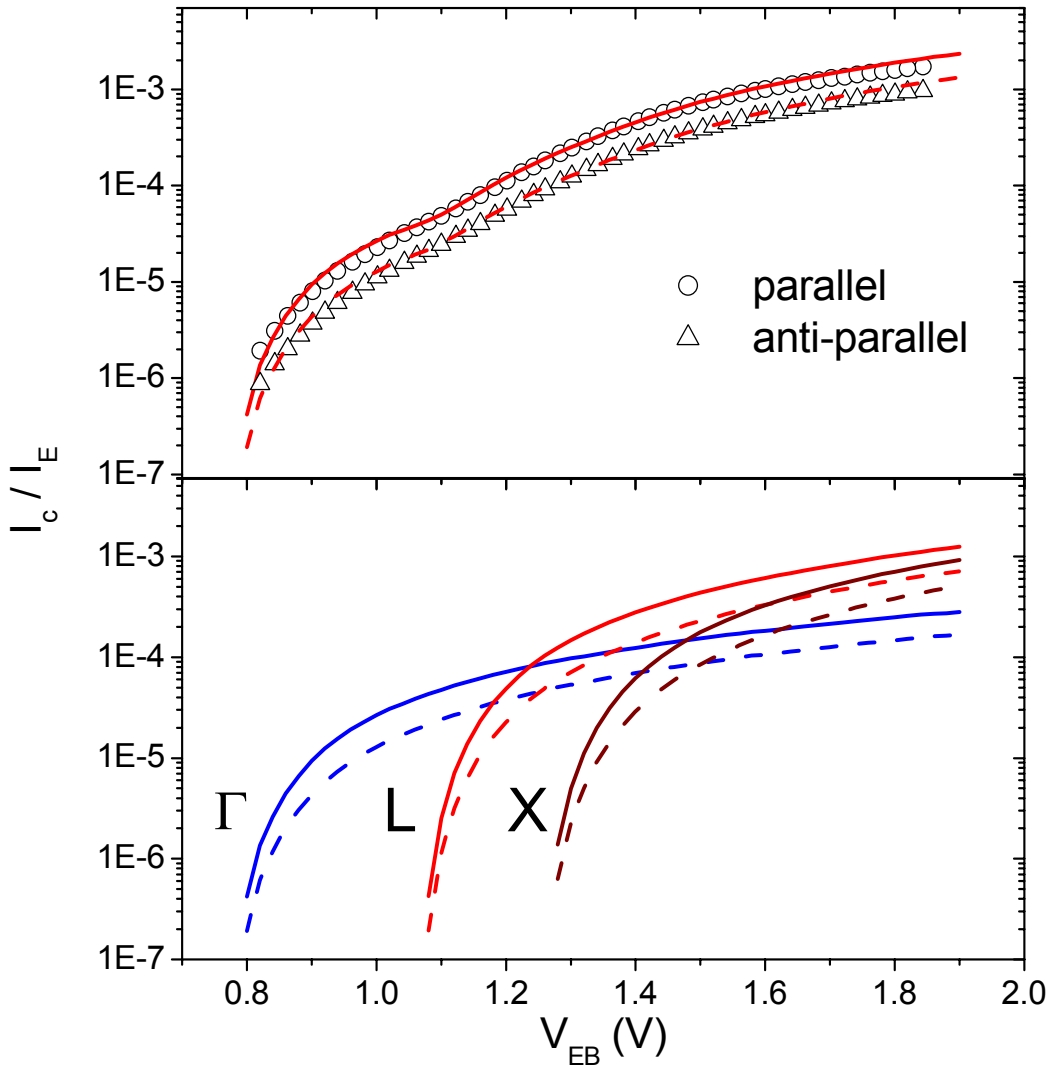
Scattering in the base broadens the energy and angular distribution of hot electrons.

Model



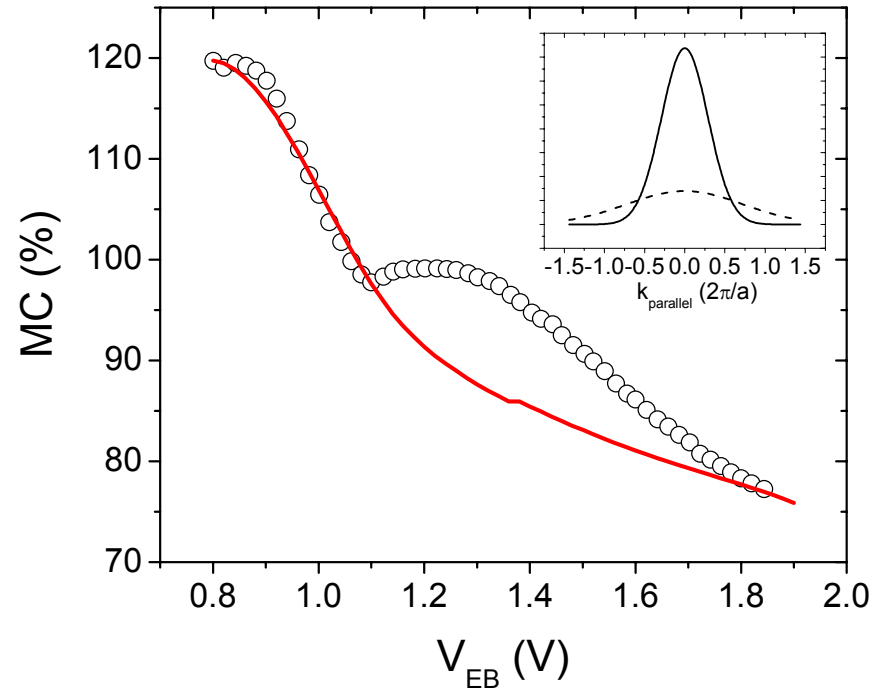
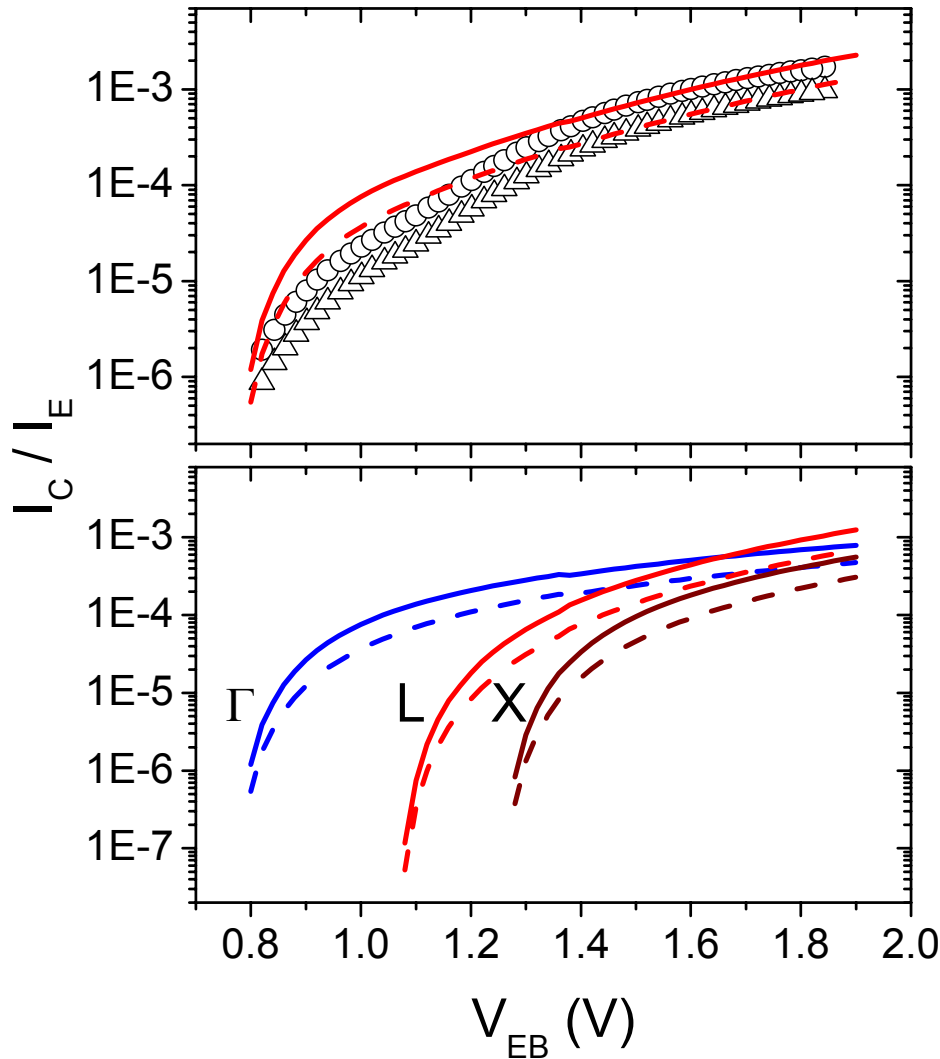
- Majority and minority electrons have different energy distribution due to spin-dependent inelastic scattering in the base layer.
- At low bias, majority electrons can be more easily collected by the collector because of their narrow energy distribution, which leads to a large MC. At high bias, more minority electrons can also be collected, which leads to a reduced MC.
- The opening of the L bands favors the injection of majority electrons and causes the non-monotonic bias dependence of the MC.

Calculation Results



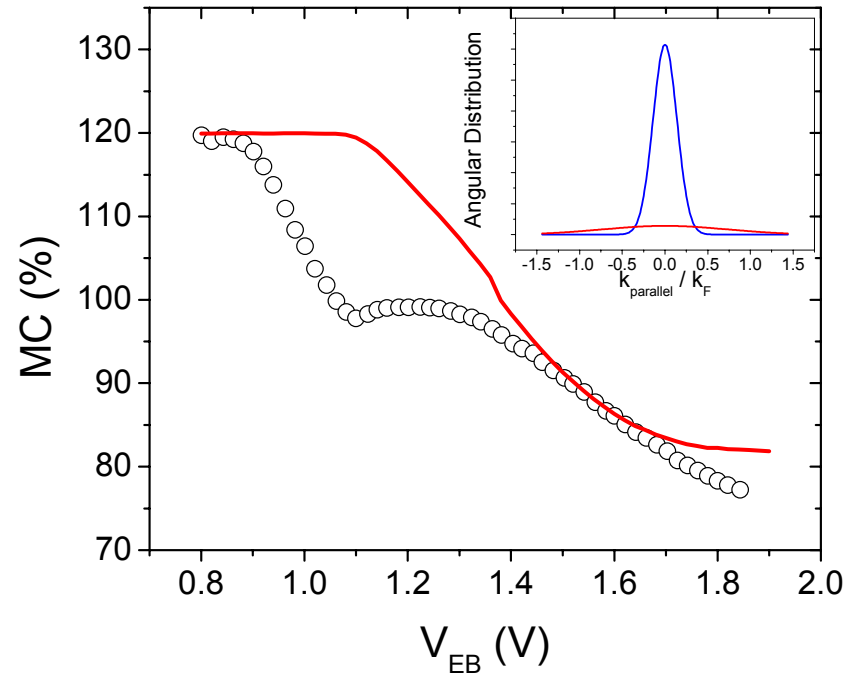
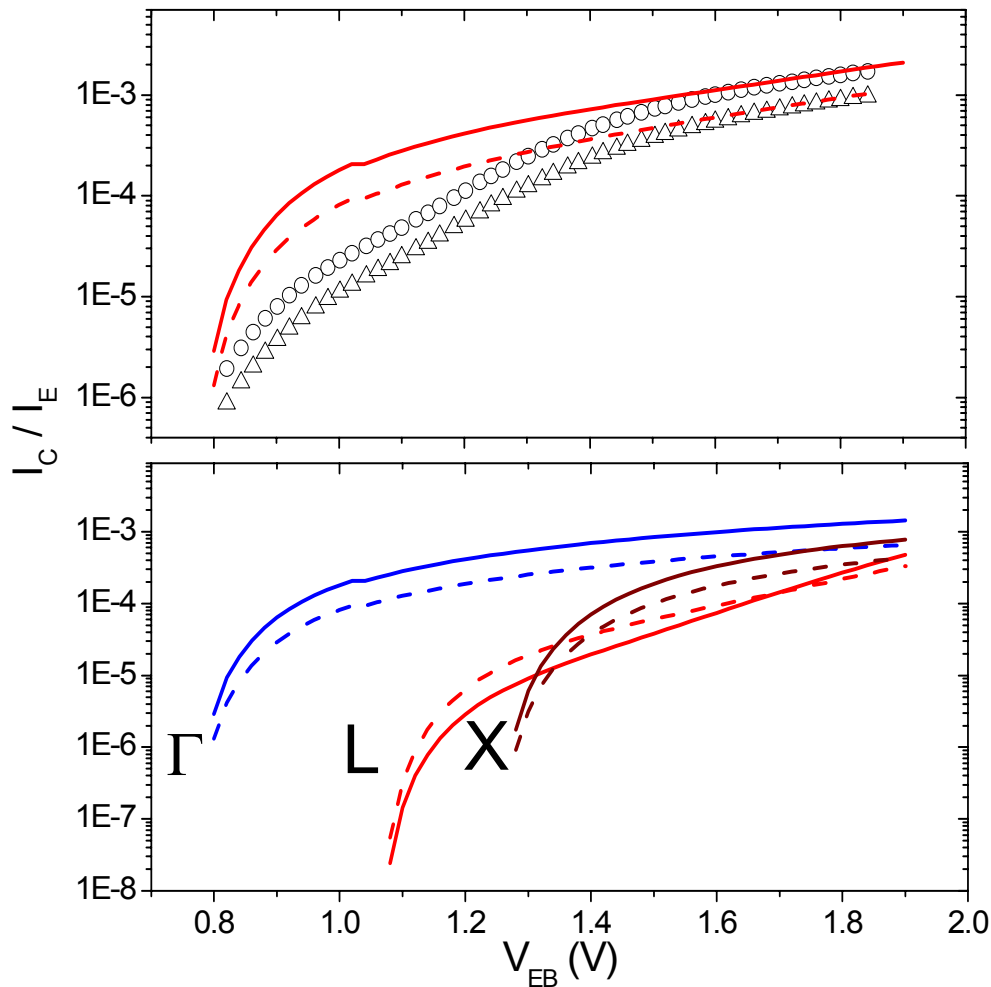
- Angular distribution: broad for both majority and minority electrons.
→ strong interface scattering
- Energy distribution: broader for minority electrons than for majority electrons.

Narrow Angular Distribution



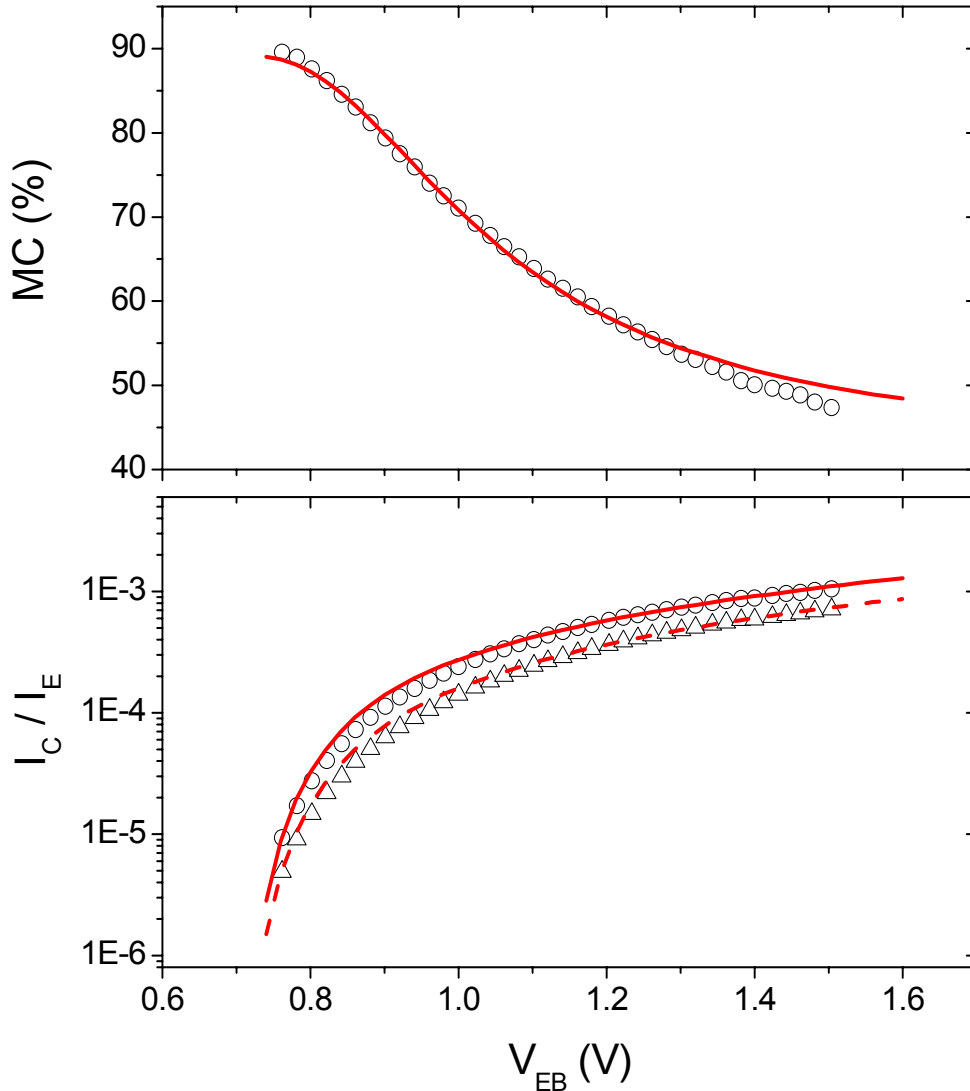
For narrow angular distribution, the contribution from the L bands is very small. The non-monotonic bias dependence of MC cannot be reproduced.

Same Energy Distribution



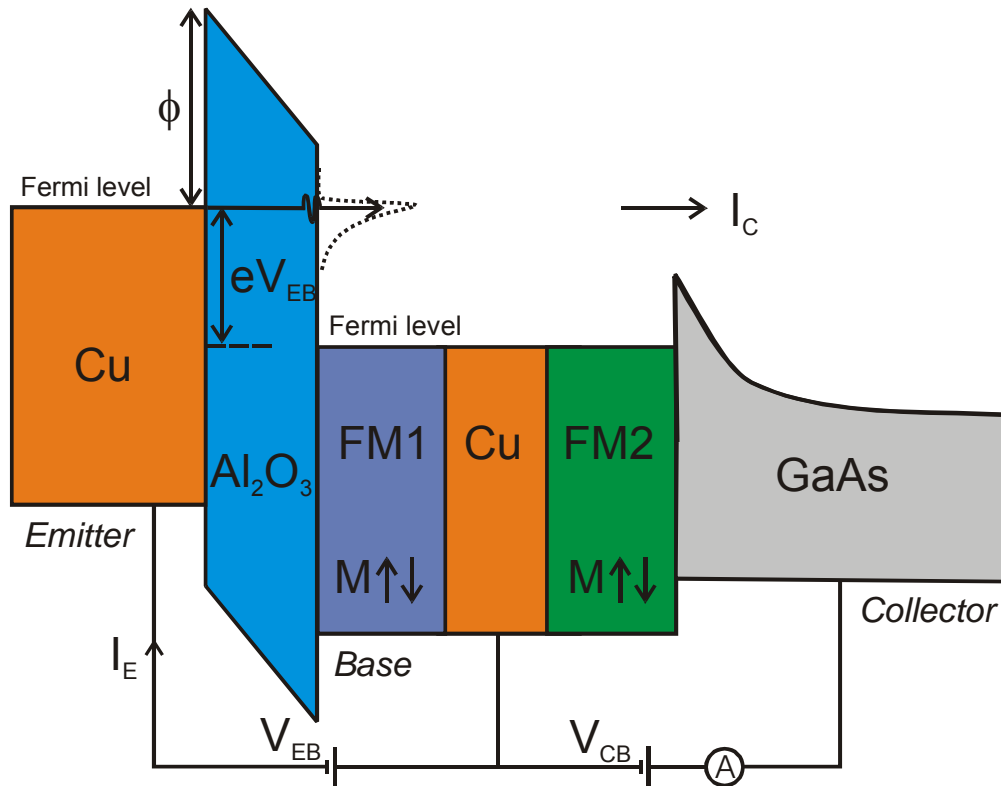
The non-monotonic bias dependence of MC cannot be reproduced without assuming different energy distribution for majority and minority electrons.

Bias Dependence of MC in MTTs with a Si Collector



- Monotonic bias voltage dependence of MC
- Conduction band structure of Si is different from that of GaAs
- Assuming broad angular distribution and different energy distribution for majority and minority electrons, the same model can well account for this monotonic bias dependence.

Magnetic Tunnel Transistor with a Spin-Valve Base



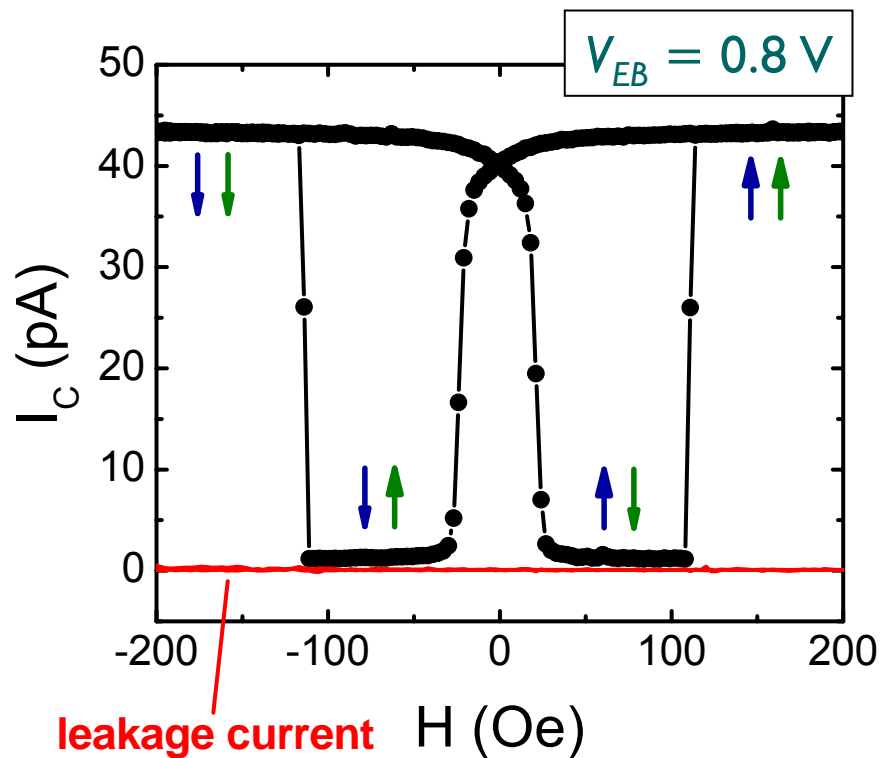
- **Nonmagnetic emitter**
- **Spin-valve base**
 - FMI and FM2 have different coercivity
- **Transmission polarization:**

$$P = \frac{e^{-t/\lambda_{\uparrow}} - e^{-t/\lambda_{\downarrow}}}{e^{-t/\lambda_{\uparrow}} + e^{-t/\lambda_{\downarrow}}}$$

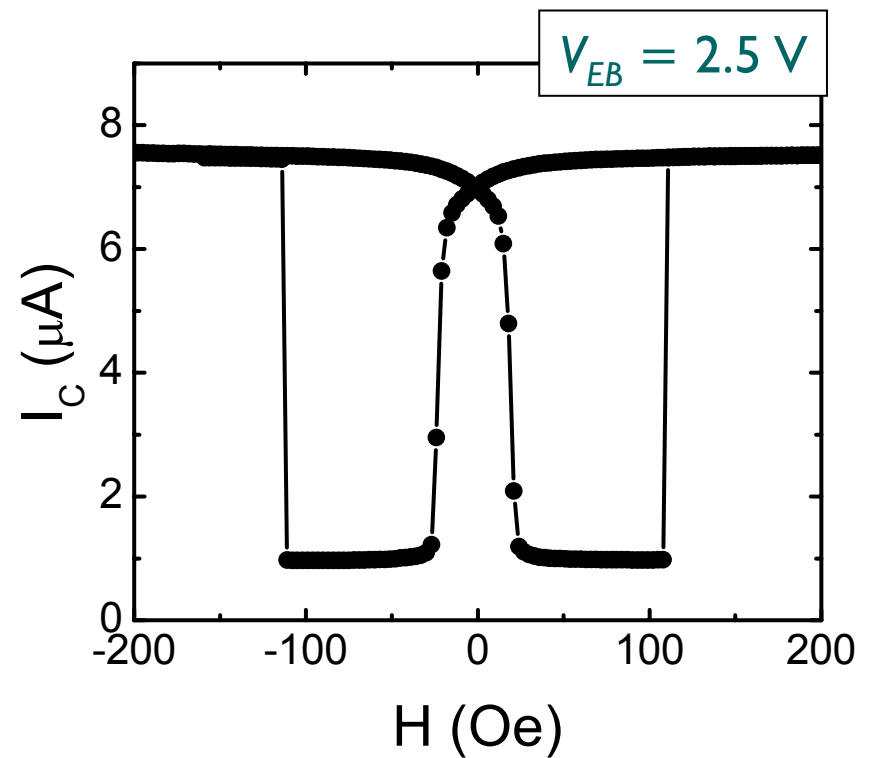
3400% MC

Spin-valve: 50 Å Ni₈₁Fe₁₉ / 40 Å Cu / 50 Å Co₇₀Fe₃₀

MC = 3420 %
 $I_C = 43 \text{ pA}$

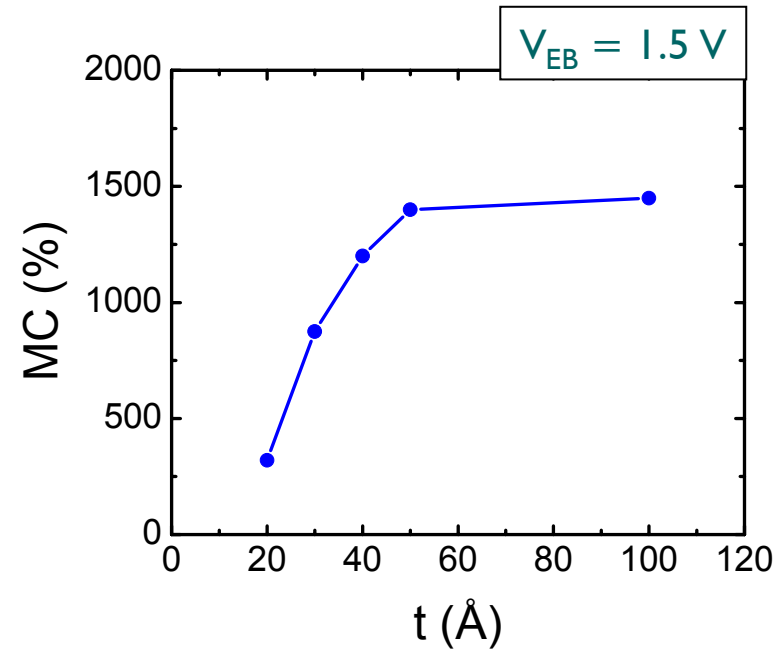
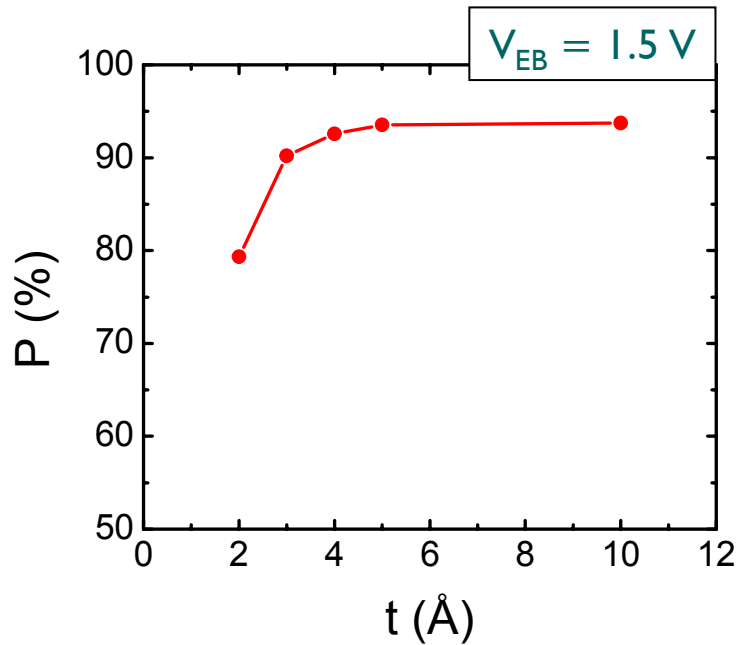


MC = 670 %
 $I_C = 7.5 \text{ } \mu\text{A}$



Spin Filtering

t Å NiFe / 40 Å Cu / t Å CoFe



Transmission Polarization :

$$P = \frac{n_{\uparrow} - n_{\downarrow}}{n_{\uparrow} + n_{\downarrow}} = \frac{e^{-t/\lambda_{\uparrow}} - e^{-t/\lambda_{\downarrow}}}{e^{-t/\lambda_{\uparrow}} + e^{-t/\lambda_{\downarrow}}}$$

Magnetocurrent :

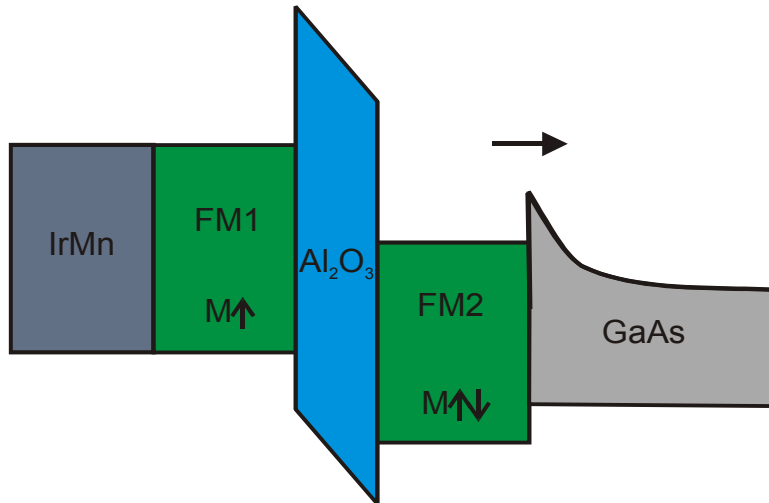
$$MC = \frac{I_{C,P} - I_{C,AP}}{I_{C,AP}} = \frac{2P_1P_2}{1 - P_1P_2}$$

MC: Single Layer Base MTT vs. Spin-Valve Base MTT

$$MC = 2P_1P_2 / (1 - P_1P_2)$$

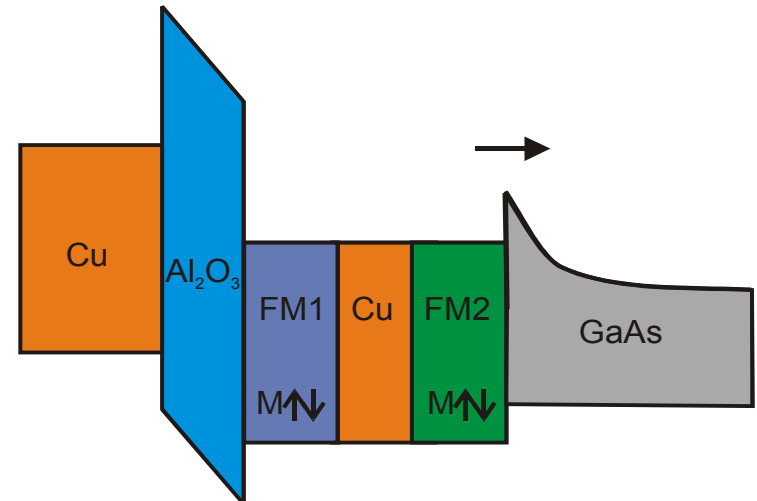
P_1, P_2 : Density of states polarization ($\sim 40\%$) or transmission polarization ($> 95\%$)

Single layer base MTT



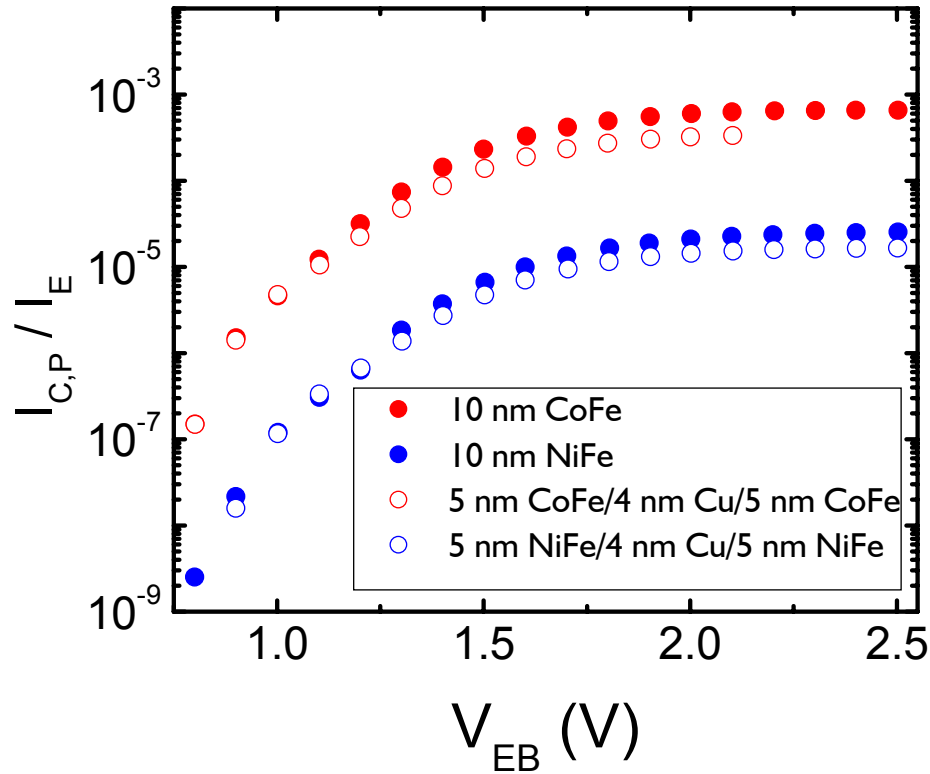
$P_1 = 40\%, P_2 = 95\%$
 $\rightarrow MC = 123\%$

Spin-valve base MTT



$P_1 = 95\%, P_2 = 95\%$
 $\rightarrow MC = 1850\%$

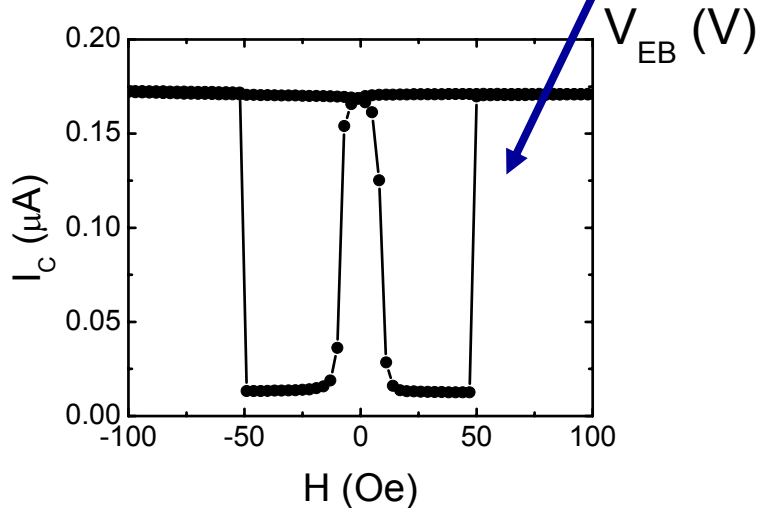
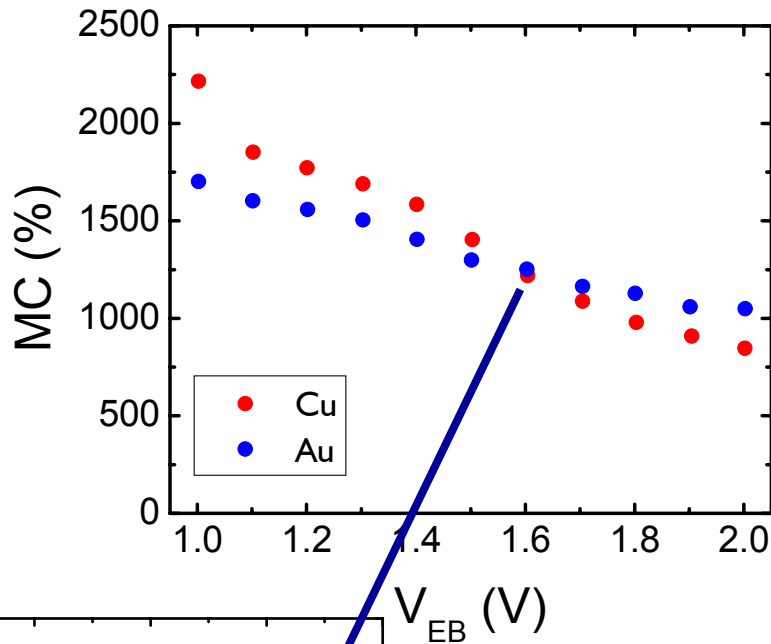
Interface Scattering



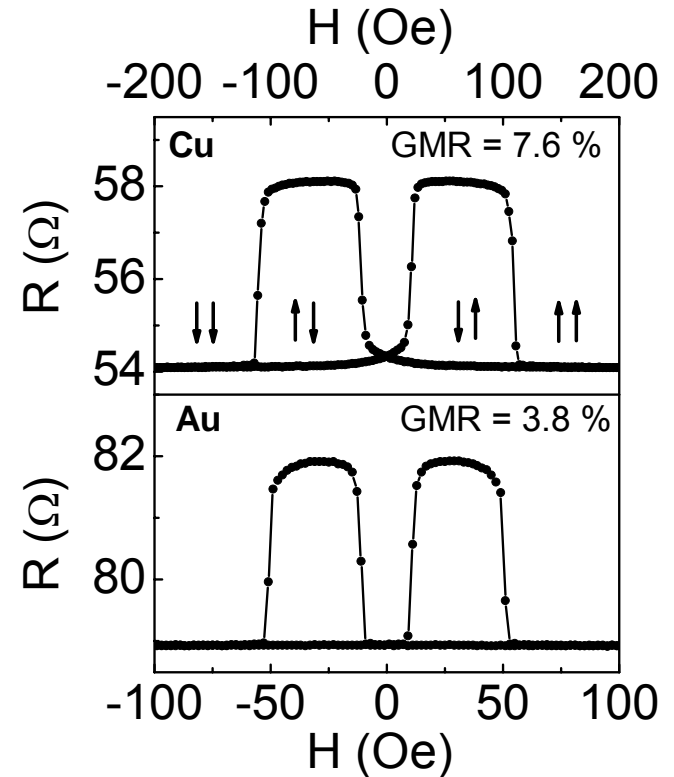
- Hot electron scattering at CoFe/Cu and NiFe/Cu interfaces negligible
- Strong hot electron scattering at NiFe/GaAs interface than at CoFe/GaAs interface

MC: Cu vs. Au Space Layers

50 Å NiFe / 40 Å Au or Cu / 50 Å CoFe



50 Å NiFe/40 Å Au/50 Å CoFe



■ **Similar MC for Cu and Au spacers**

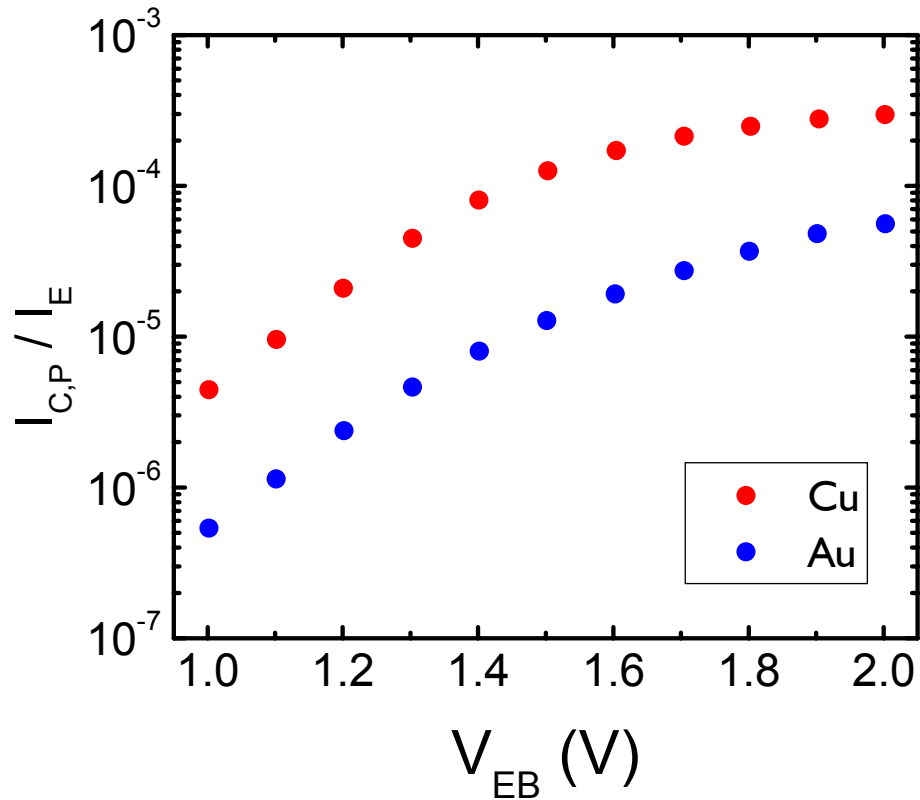
→ spin transport in MTTs dominated by bulk effect

■ **Very different GRM of the spin-valve with Cu and Au spacers**

→ GMR effect dominated by interface effect

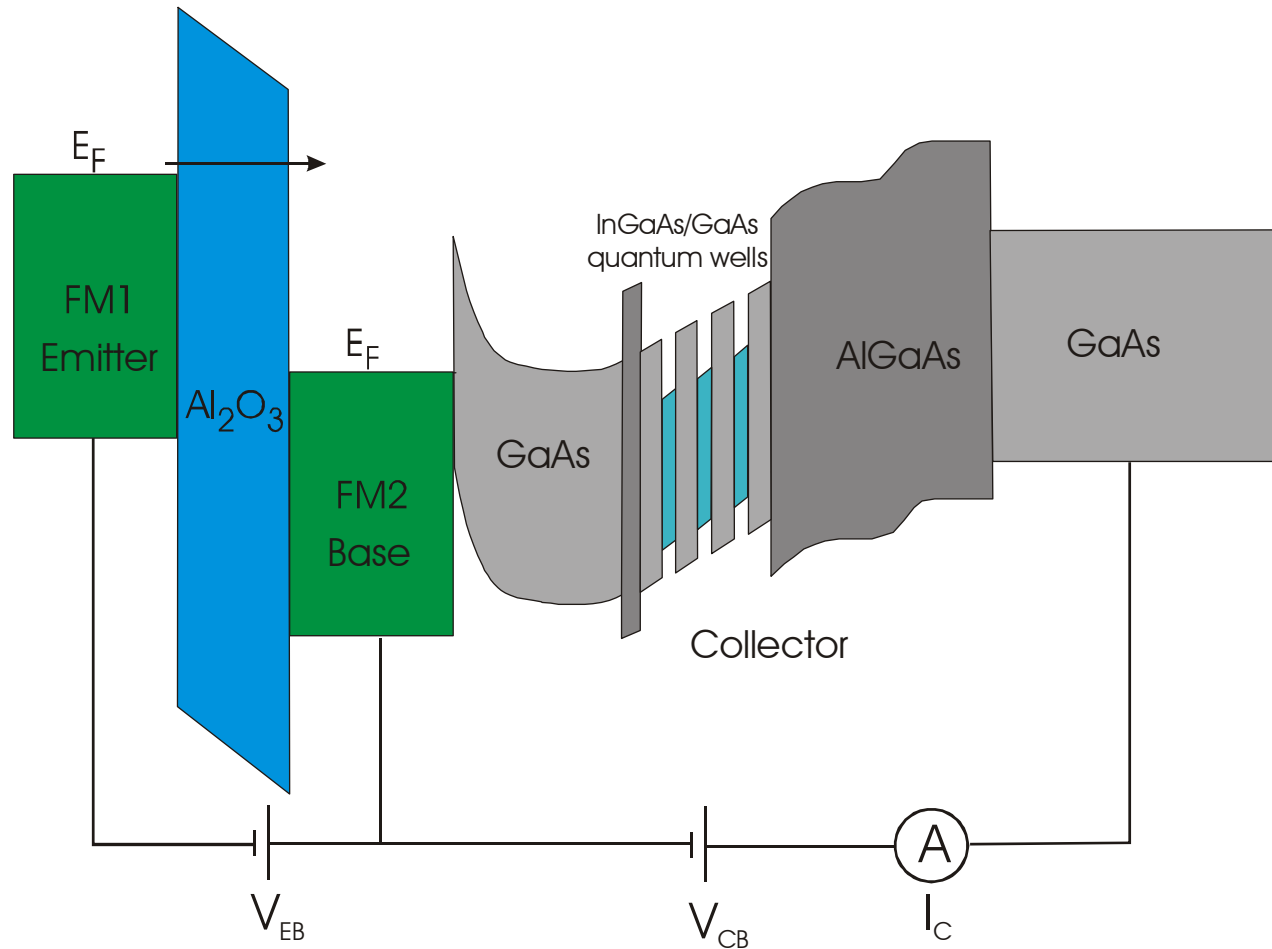
TR: Cu vs. Au Space Layer

50 Å NiFe / 40 Å Au or Cu / 50 Å CoFe



Strong hot electron scattering at the
CoFe/Au and NiFe/Au interfaces

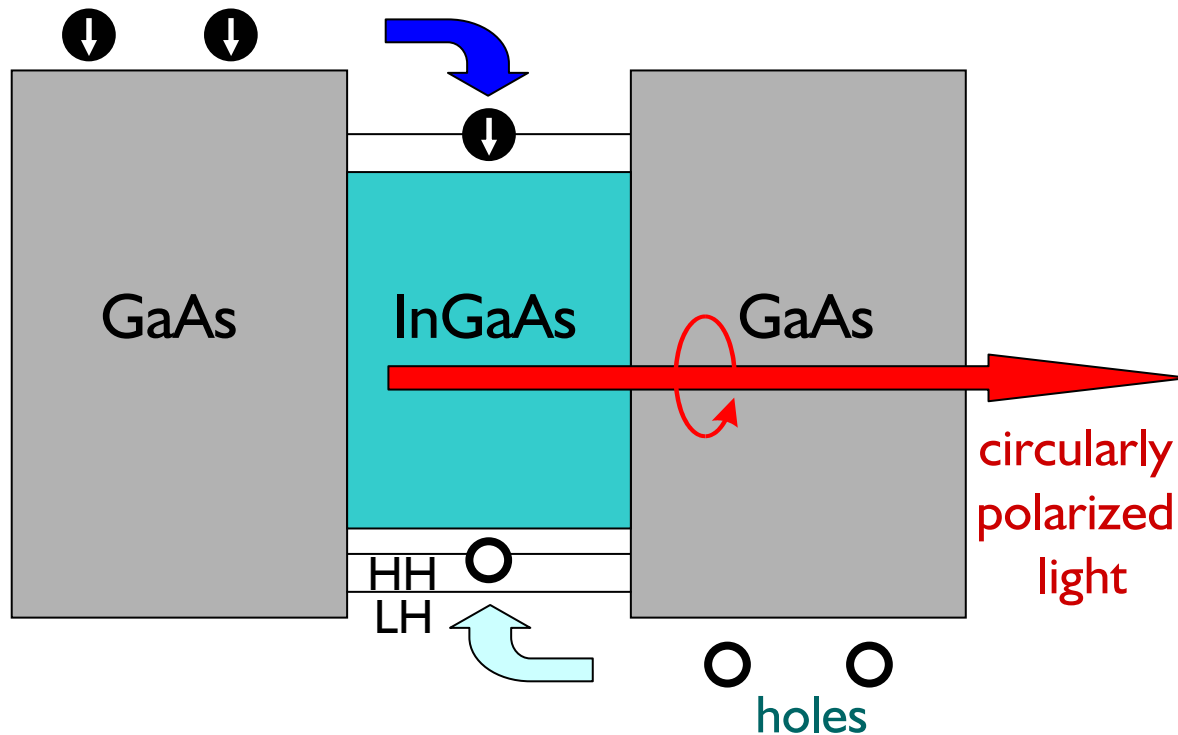
Electrical Spin Injection from MTTs into GaAs



p^+ -GaAs / p-AlGaAs / i-AlGaAs / [GaAs / InGaAs QW]₃ / i-AlGaAs /
n-GaAs / NiFe / CoFe / Al_2O_3 / CoFe / Ta

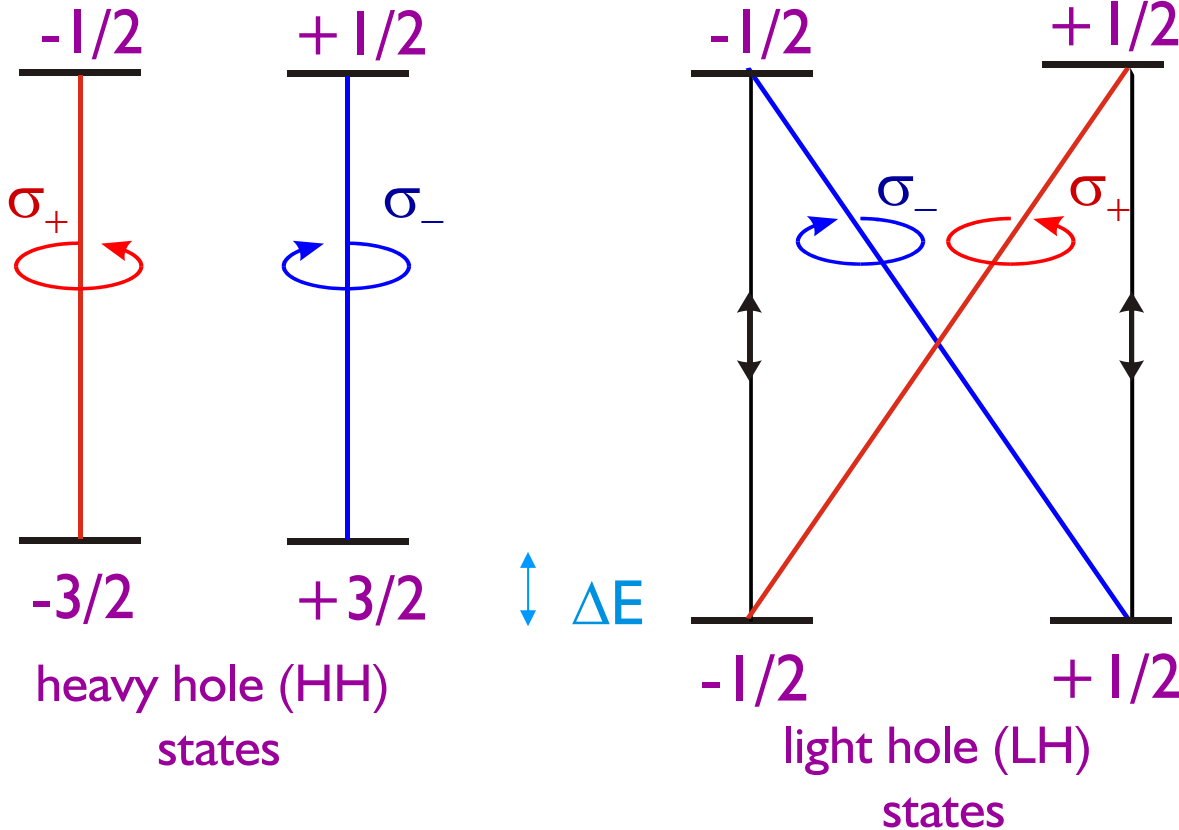
Electron-Hole Recombination in Quantum Wells

Spin-polarized electrons



- Spin-polarized electrons recombine with holes in the QWs and emit circularly polarized light.
- The spin polarization can be determined by measuring the polarization of the light.

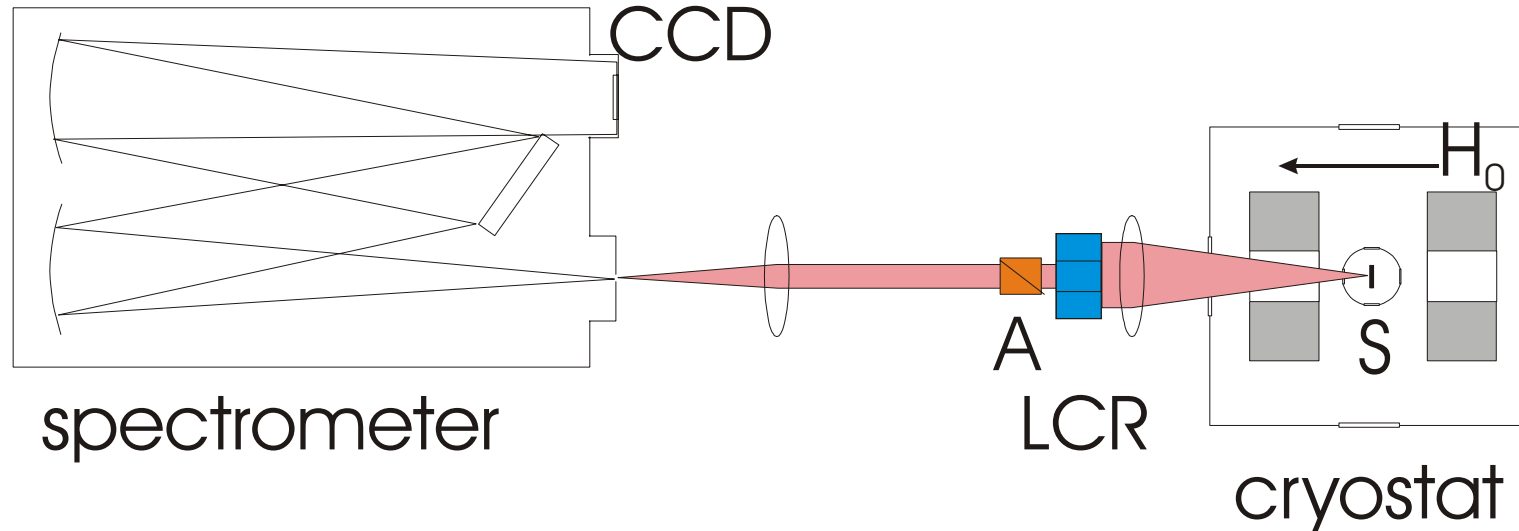
Optical Selection Rules



Selection Rules:

- In quantum wells, the degeneracy of heavy and light holes is lifted. As a result, it is possible to measure electron-HH recombination only.
- Electroluminescence (EL) polarization reflects electron spin polarization right before they recombine with heavy holes.

Experiment Set-up



Optical Setup:

- Faraday geometry: magnetic field parallel to light propagation.
- Liquid crystal retarder (LCR) and linear polarizer (A) select the polarization components of the EL.
- Light intensity measured with a charge coupled device (CCD).

Spin Relaxation Mechanism

■ Elliott-Yafet (EY) mechanism :

- Spin-orbit coupling mixes electron wave functions with opposite spin states
- Momentum scattering can cause spin relaxation.
- Spin relaxation rate:

$$1 / \tau_S \propto 1 / \tau_p \rightarrow 1 / \tau_p \text{ being momentum relaxation rate}$$

■ Bir-Aronov-Pikus (BAP) mechanism:

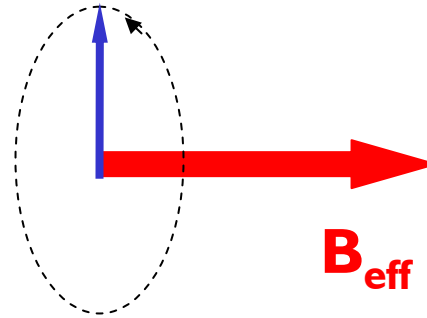
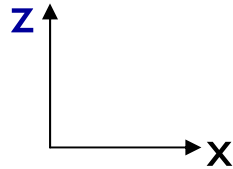
- Spin relaxation due to electron-hole interactions
- Spin relaxation rate proportional to hole concentration in non-degenerate case

■ D'yakonov-Perel' (DP) mechanism:

- Effective magnetic field: $H = -g \hbar (\boldsymbol{\sigma} \cdot \mathbf{B}_{\text{EFF}}) / 2, \mathbf{B}_{\text{EFF}} = \mathbf{B}_{\text{EFF}}(\mathbf{p}) \propto \mathbf{E}^n$
- Spin relaxation due to precession in the effective magnetic field
- Spin relaxation rate: $1 / \tau_S \propto \tau_p$

DP Relaxation Mechanism

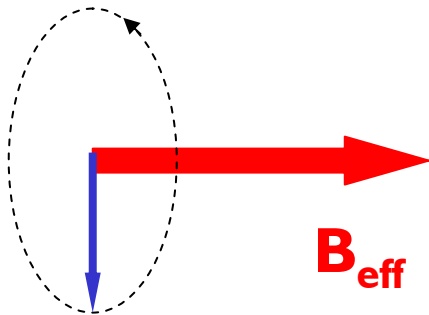
Injected spin along z-axis, effective magnetic field along x-axis



large τ_p :

$$\langle S_z \rangle = 0$$

spin relaxation is effective

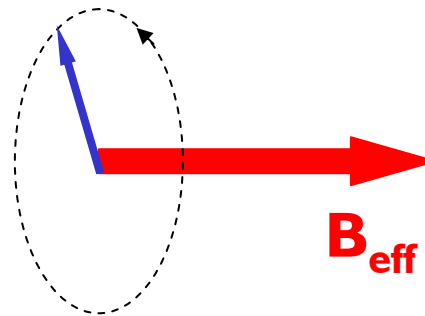


no momentum scattering

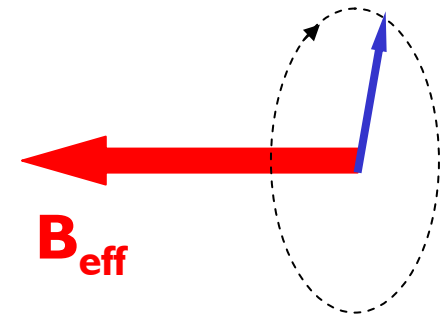
small τ_p :

$$\langle B \rangle = 0$$

spin relaxation is suppressed

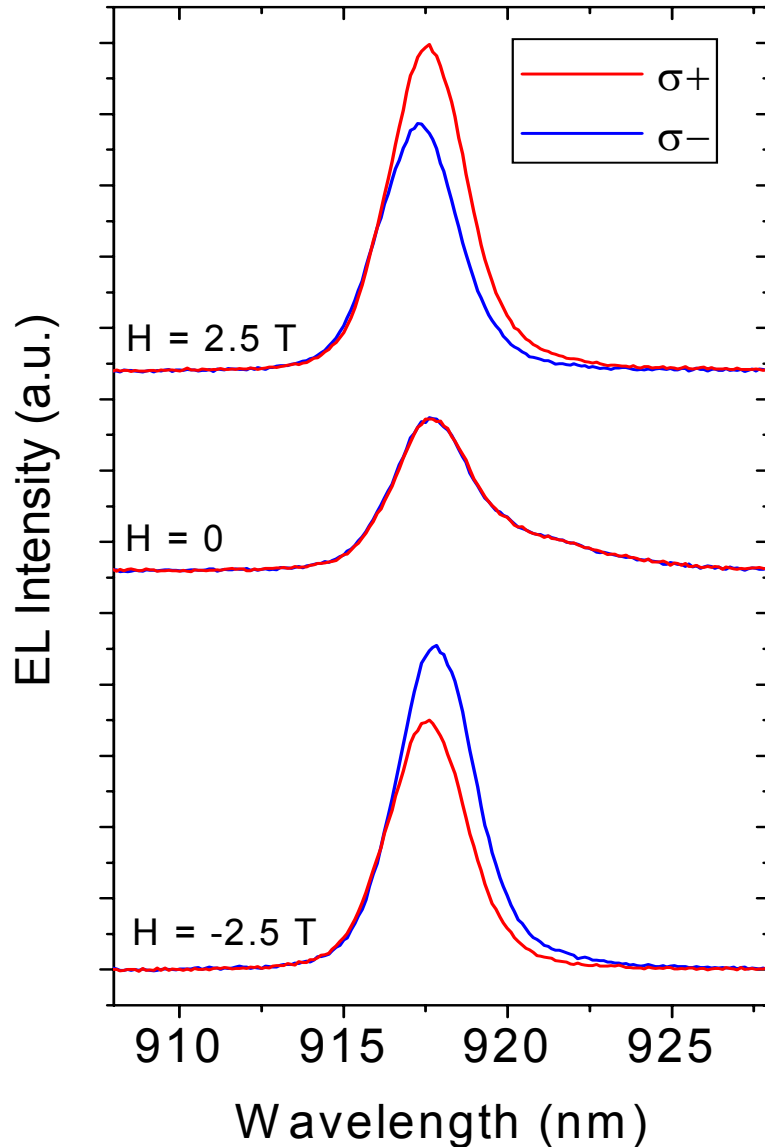


before scattering



after scattering

Electroluminescence



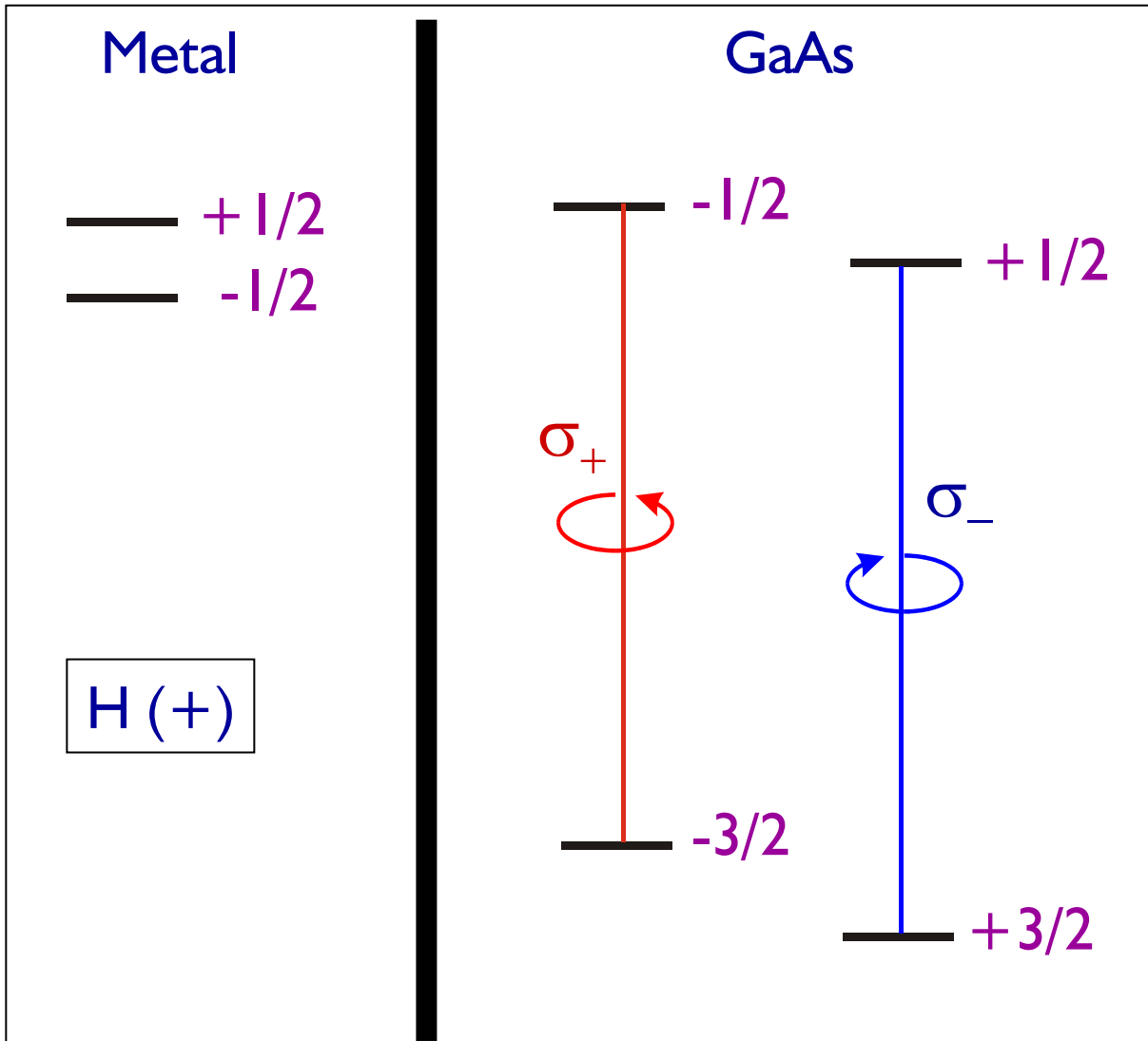
■ $T = 1.4$ K, $V_{EB} = -2.06$ V, $V_{CB} = 1.0$ V

■ EL polarization defined as:

$$P_{EL} = (I_+ - I_-) / (I_+ + I_-)$$

I_+ and I_- being EL intensities for σ_+ and σ_- components respectively.

Majority Spin Injection



- Zeeman splitting

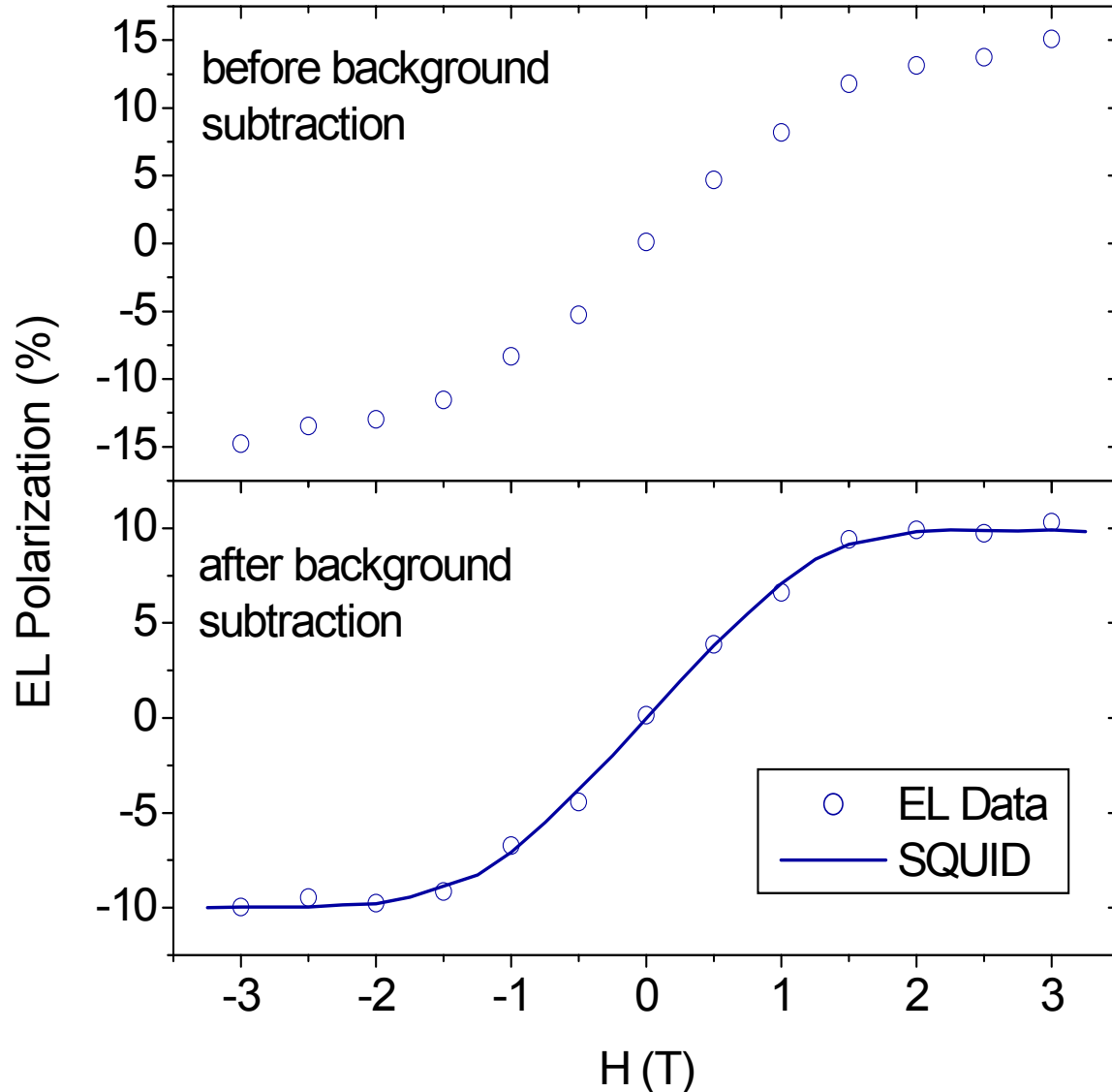
$$\Delta E = -g \mu H m_s$$

- Metal: $g_e \sim 2$

$$\text{GaAs: } g_e \sim -0.44$$

- Positive EL polarization in positive field \rightarrow majority spin injection

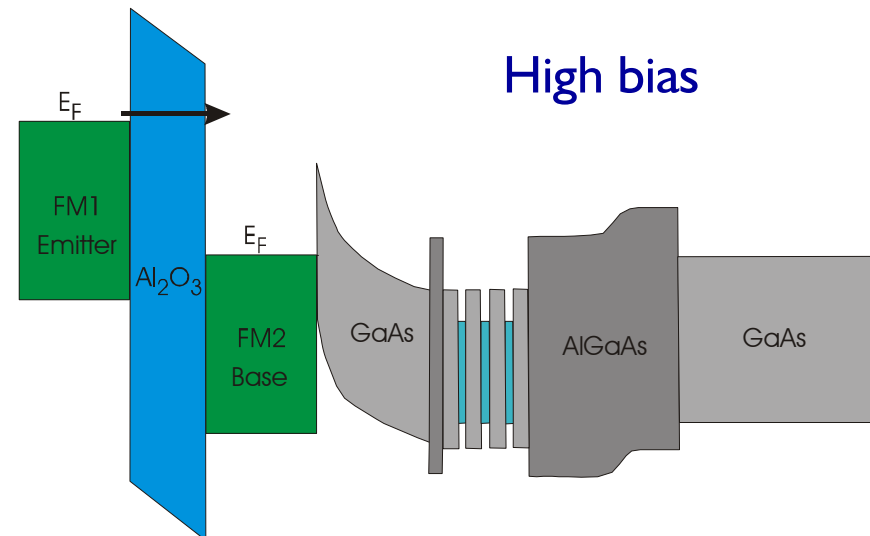
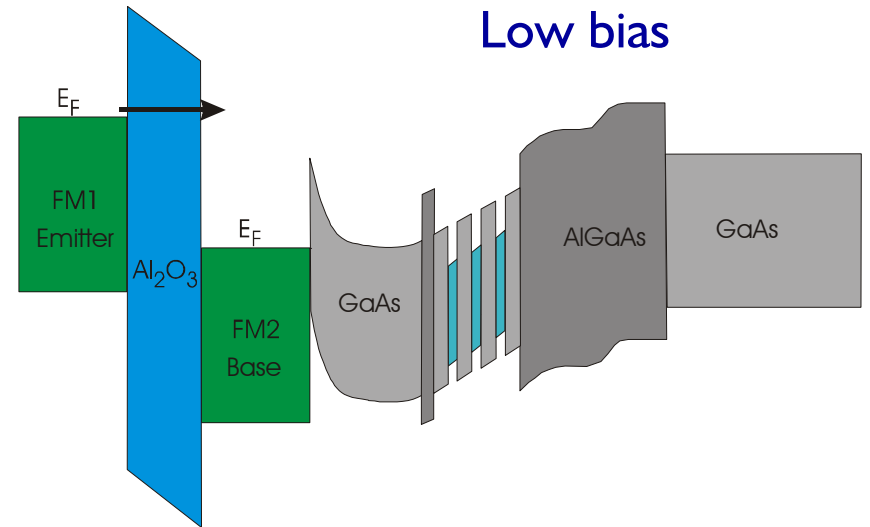
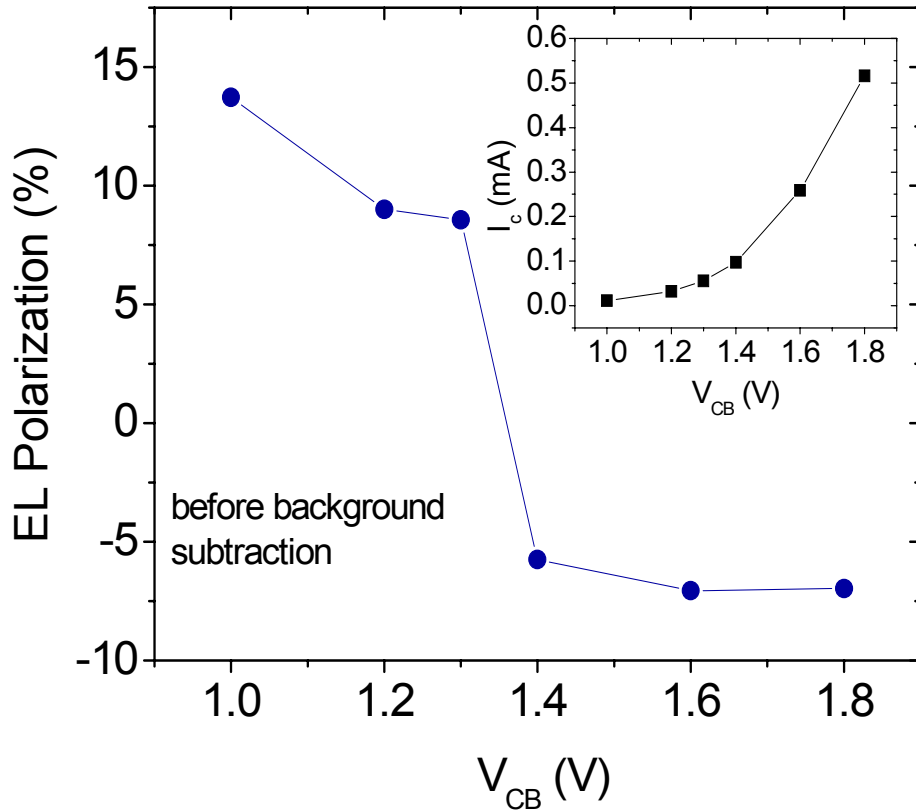
Field Dependence of EL Polarization



- Background polarization due to thermalization of spins in the magnetic field.
- After subtracting a linear background, the EL polarization data agrees with the SQUID data very well.
- EL polarization up to ~10%.

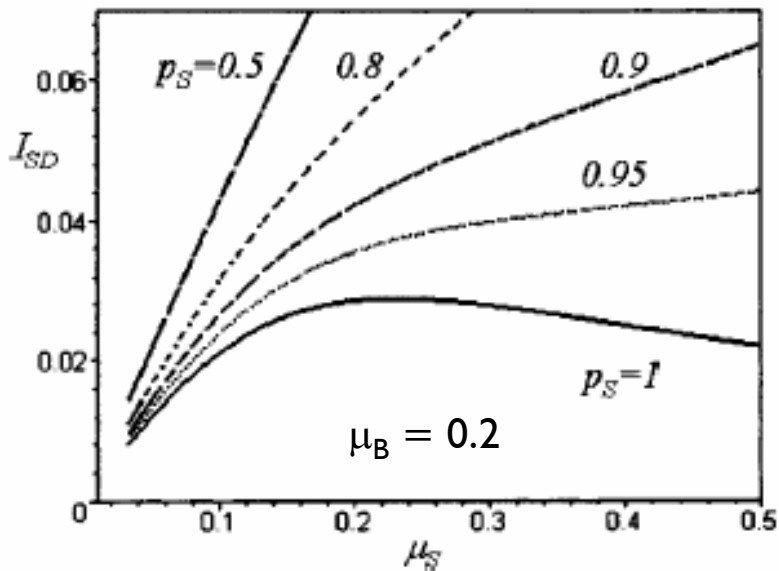
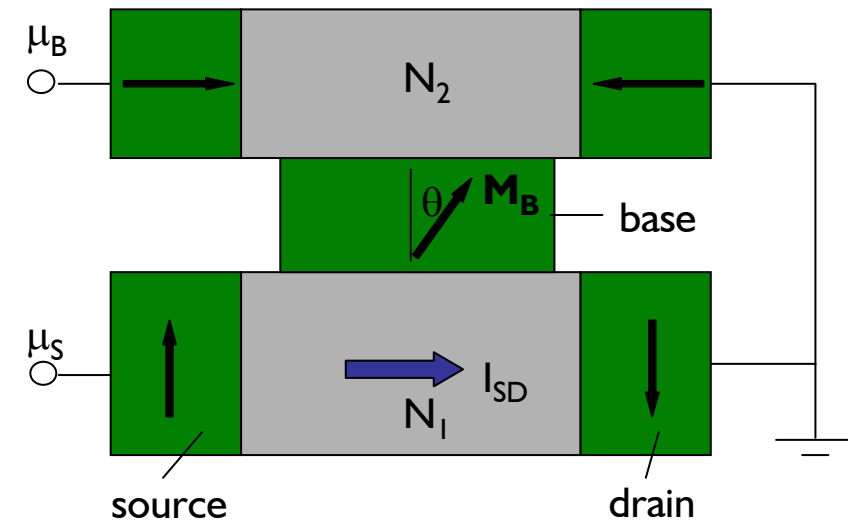
Bias Dependence of EL Polarization

$T = 1.4 \text{ K}, H = 2.5 \text{ T}$



- Strong bias dependence of EL polarization
- Most likely related to spin relaxation process:
 - DP mechanism
 - BAP mechanism

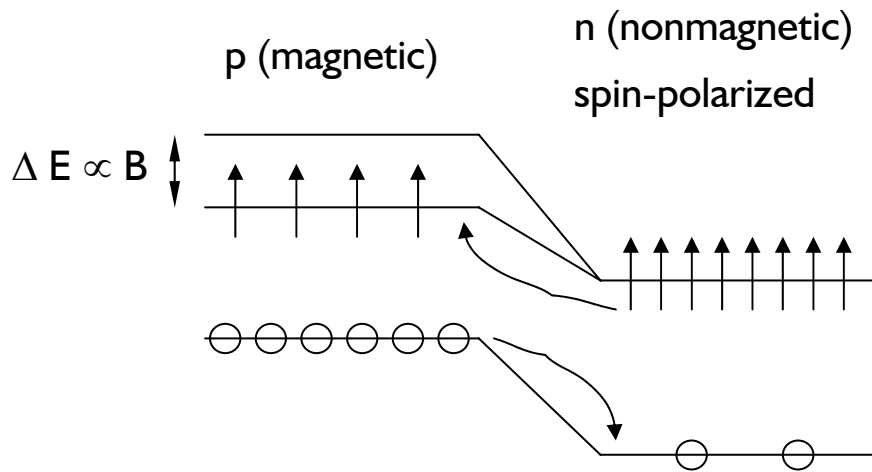
Spin-Torque Transistor



G. E. W. Bauer, A. Brataas, Y. Tsekovnyak, and B. J. van Wees, *Appl. Phys. Lett.* **82**, 3928 (2000).

- μ_S generates source drain current I_{SD} .
→ spin accumulation in normal metal N_1
- Orientation of magnetization M_B in the base influences spin accumulation in N_1 .
→ I_{SD} can be modulated by varying θ
- Spin transfer from N_1 and N_2 into the base produces torque on M_B . The resulting angle θ depends on both μ_B and μ_S .
→ I_{SD} can be modulated by varying μ_B
- Negative differential resistance and gain can be achieved.

Magnetic p-n Junctions



■ n-region (nonmagnetic)

→ spin-polarized due to spin injection

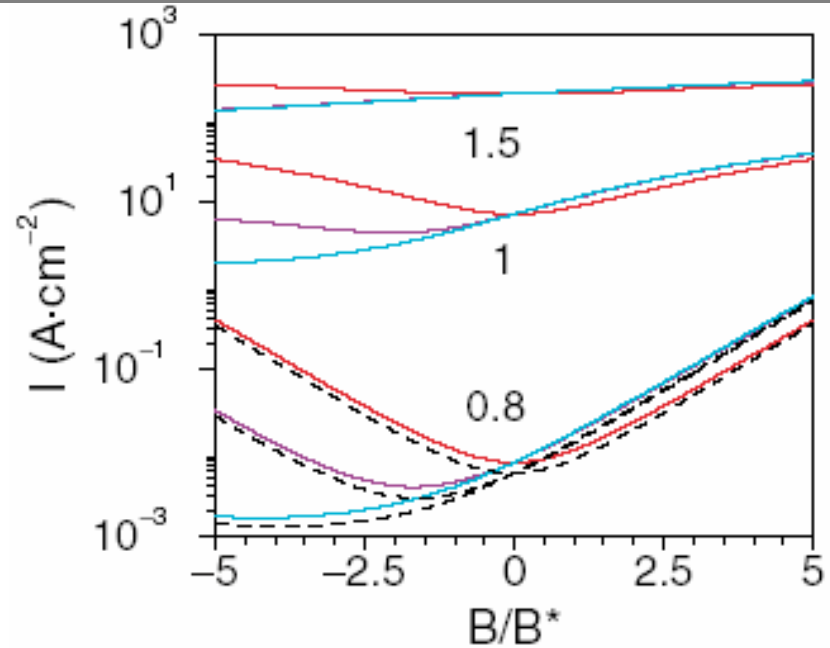
■ p-region (magnetic)

→ spin subband splitting in magnetic field

$$\Delta E = 2 g \mu_B B$$

→ barrier height for electron current depends on magnetic field

→ current varies exponentially with magnetic field



$$B^* = 2 k_B T / g \mu_B$$

α : spin polarization in n-region

τ : spin relaxation time

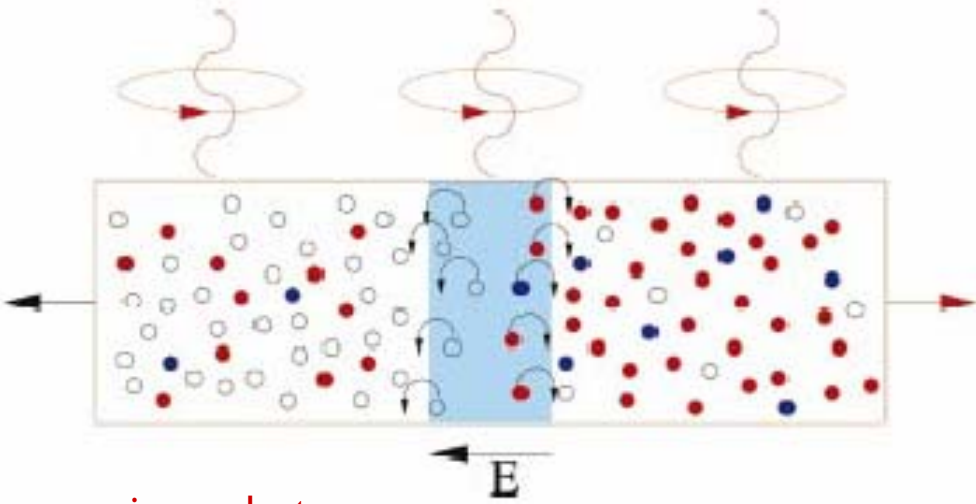
red: $\alpha = 0$, $\tau = 0.2$ ns

violet: $\alpha = 1$, $\tau = 20$ ns

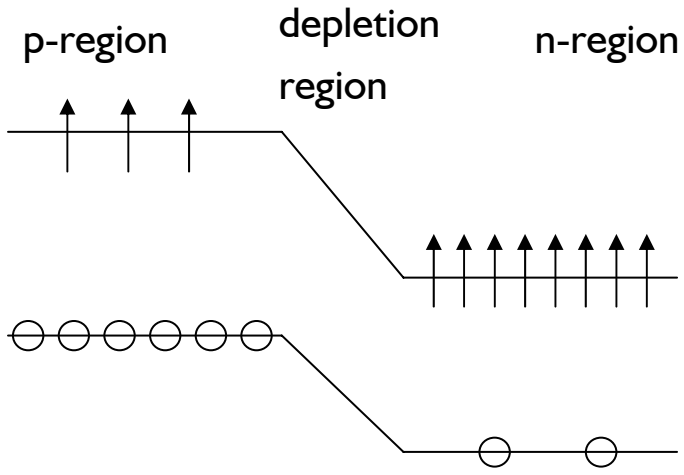
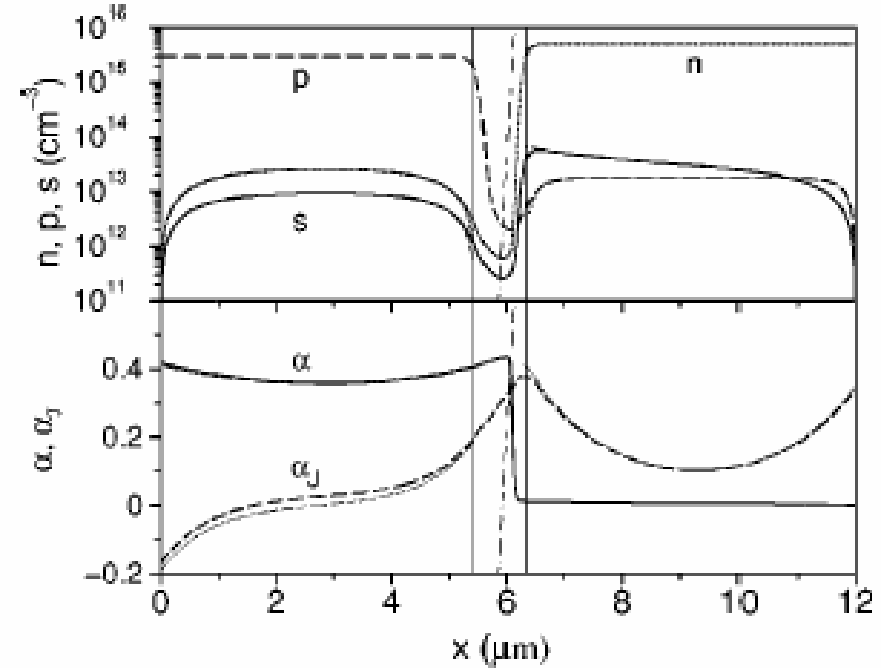
cyan: $\alpha = 1$, $\tau = 2$ μ s

I. Žutić, J. Fabian, and S. Das Sarma,
Phys. Rev. Lett. **88**, 066603 (2002).

Spin-Polarized Solar Battery



- spin up electrons
- spin down electrons



- **p-n junction illuminated by circularly polarized light**
- **Depletion region: built-in field**
 - spin-polarized electrons swept into p-region
 - unpolarized holes swept into n-region
- **Generate both charge current and spin-polarized current**

I. Žutić, J. Fabian, and S. Das Sarma, *Appl. Phys. Lett.* **79**, 1558 (2001).

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